

SPARC/X status and plans

Massimo Ferrario
on behalf of the SPARC/X team

Microbunch instability workshop - March 25, 2010

SPARX Technical Design Report **ready** ==> 1.4 - 2.5 GeV

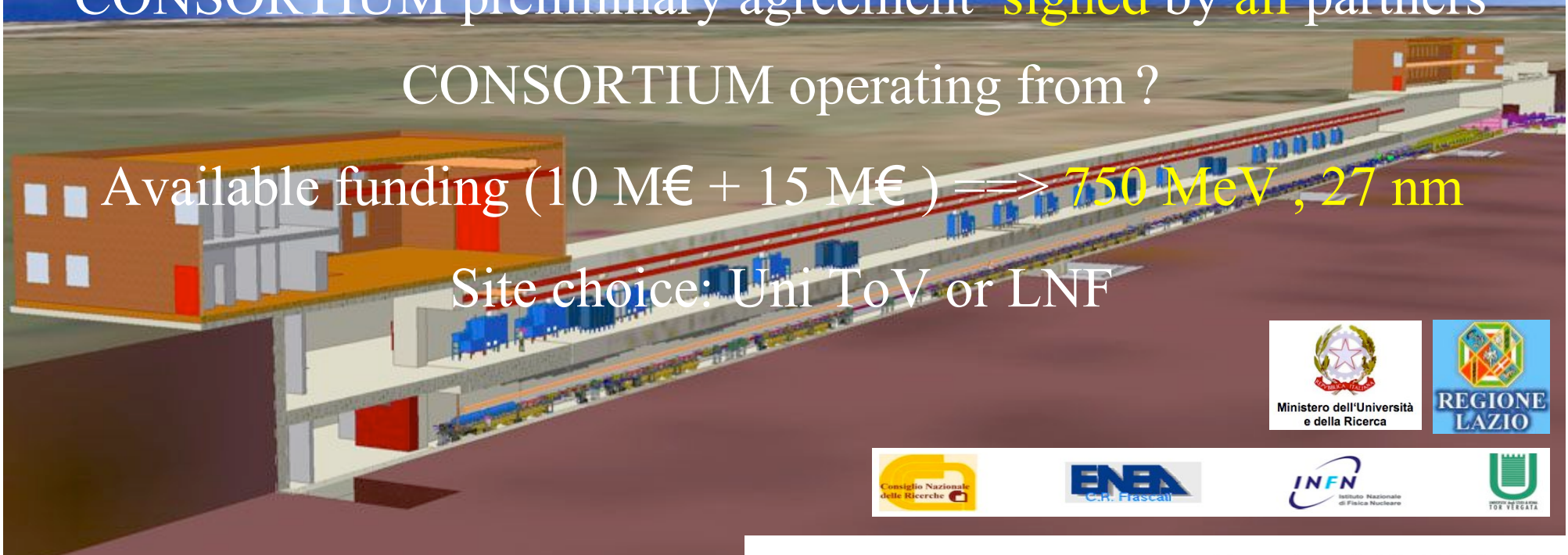
SPARX Scientific Case **ready**

CONSORTIUM preliminary agreement **signed** by **all** partners

CONSORTIUM operating from ?

Available funding (10 M€ + 15 M€) ==> **750 MeV**, **27 nm**

Site choice: Uni ToV or LNF

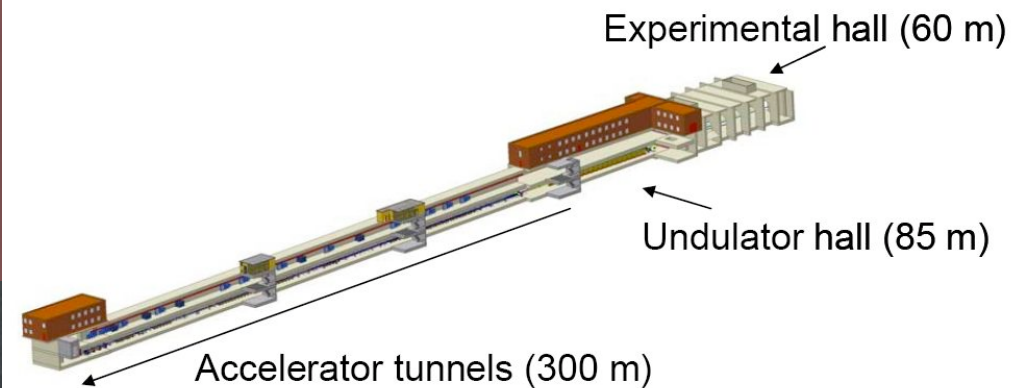


40nm - 10 nm

15nm - 5nm

5nm - 1nm

1.2nm-0.6nm



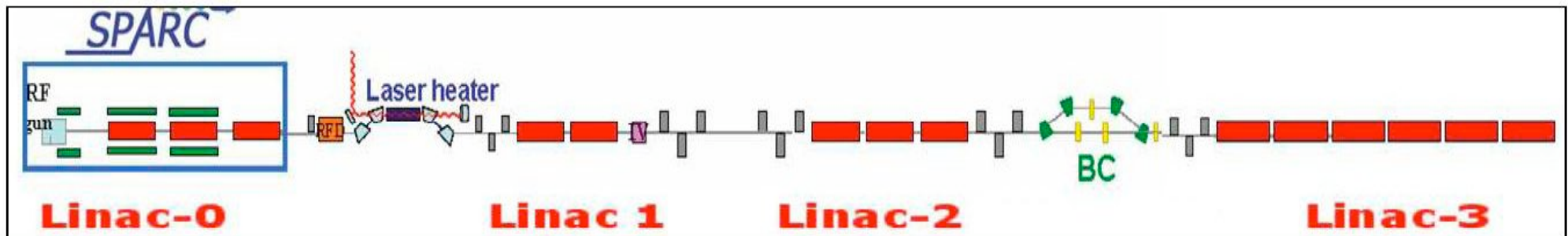
SPARX phase 0 ==> SPARC upgrade

150 MeV

125 A

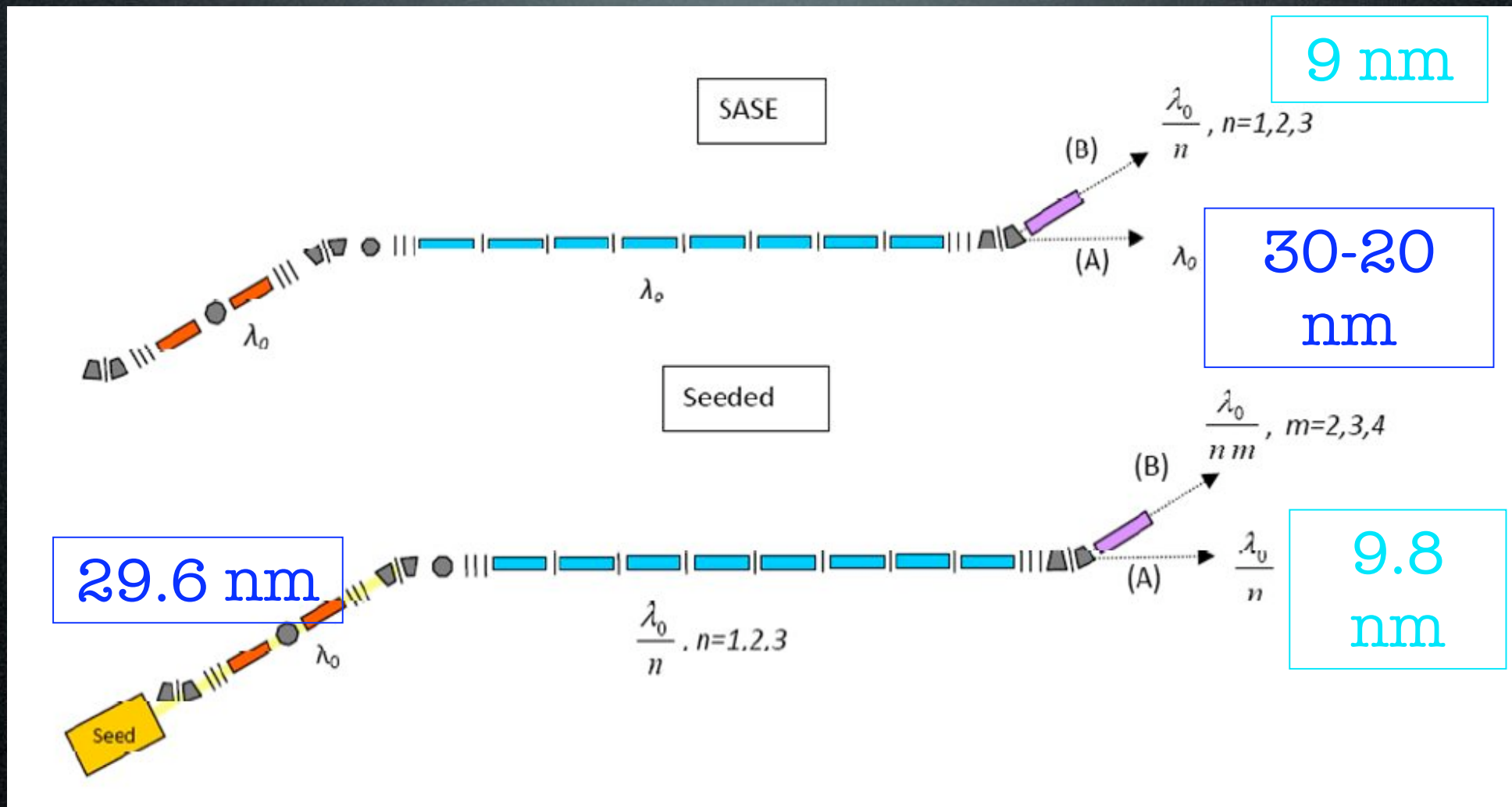
750 MeV

700 A



S-band injector with VB ==> C-band linac option

SPARX phase 0 ==> Undulators scheme



-  8xUndulator: 75 periods, $\lambda_u=28\text{mm}$ (SPARC like)
-  2xUndulator: 45 periods, $\lambda_u=44\text{mm}$
-  1xUndulator: 150 periods, $\lambda_u=17\text{mm}$

150 MeV
S-band
linac

Velocity
Bunching

12 m

Long
Solenoids

S-band
Gun

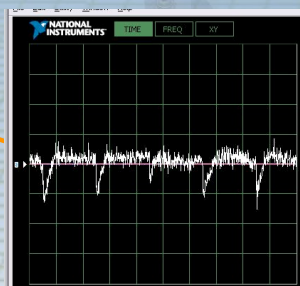
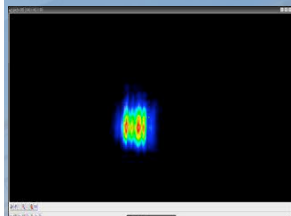
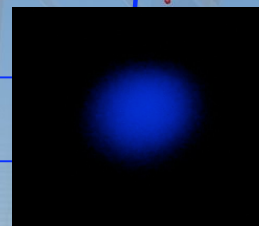
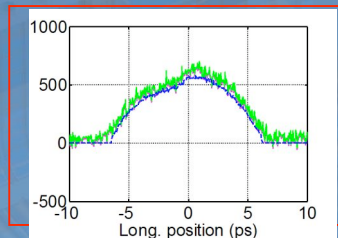
Undulators

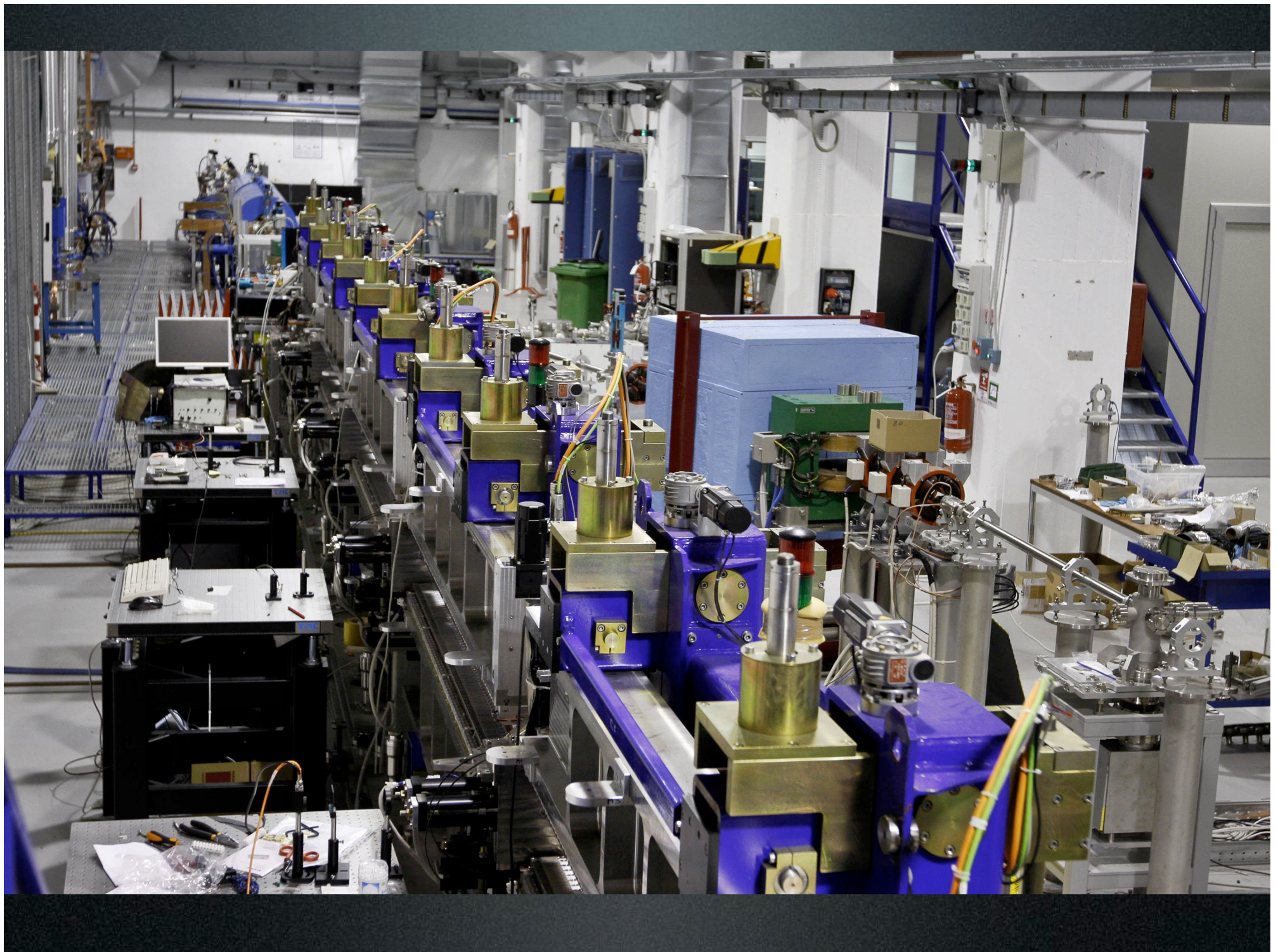
$$\lambda_u = 2.8 \text{ cm}$$

$$K_{\text{max}} = 2.2$$

$$\lambda_r = 500 \text{ nm}$$

15 m





FEL experiments: seeding and synchronization

Ti:Sa Regenerative amplifier

800 nm - 2.5 mJ – 1 kHz

+

High order harmonics

400 & 266 nm

+

High order armonics in gas:

266, 160, 114 nm

High Energy

Short duration

Spatial and temporal Coherence

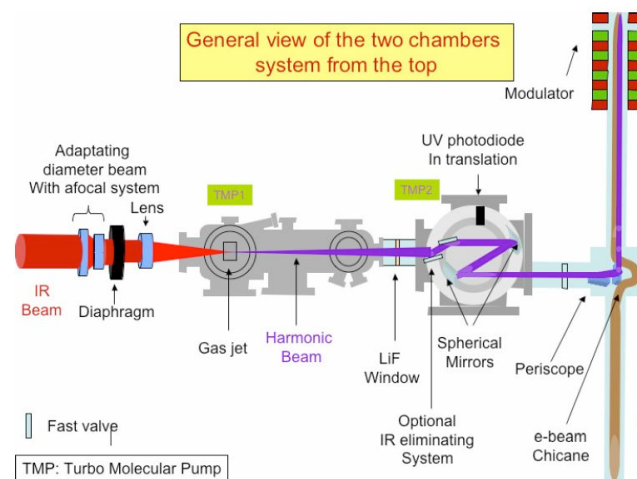
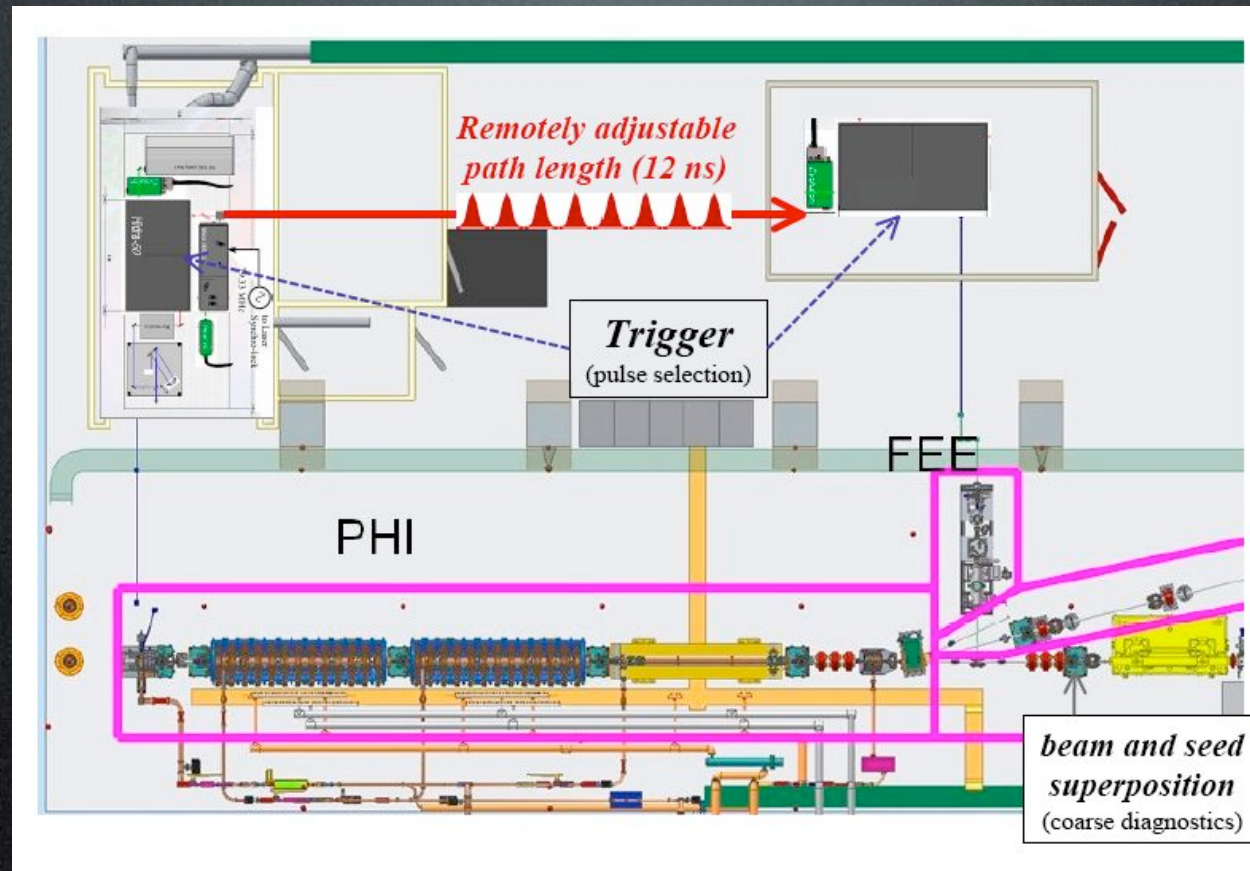


Fig. 31. Lay-out of the harmonic chamber for the seeding experiment at SPARC. The first chamber is dedicated to the production of harmonics in gas. The second chamber is required for the optical mode adaptation.



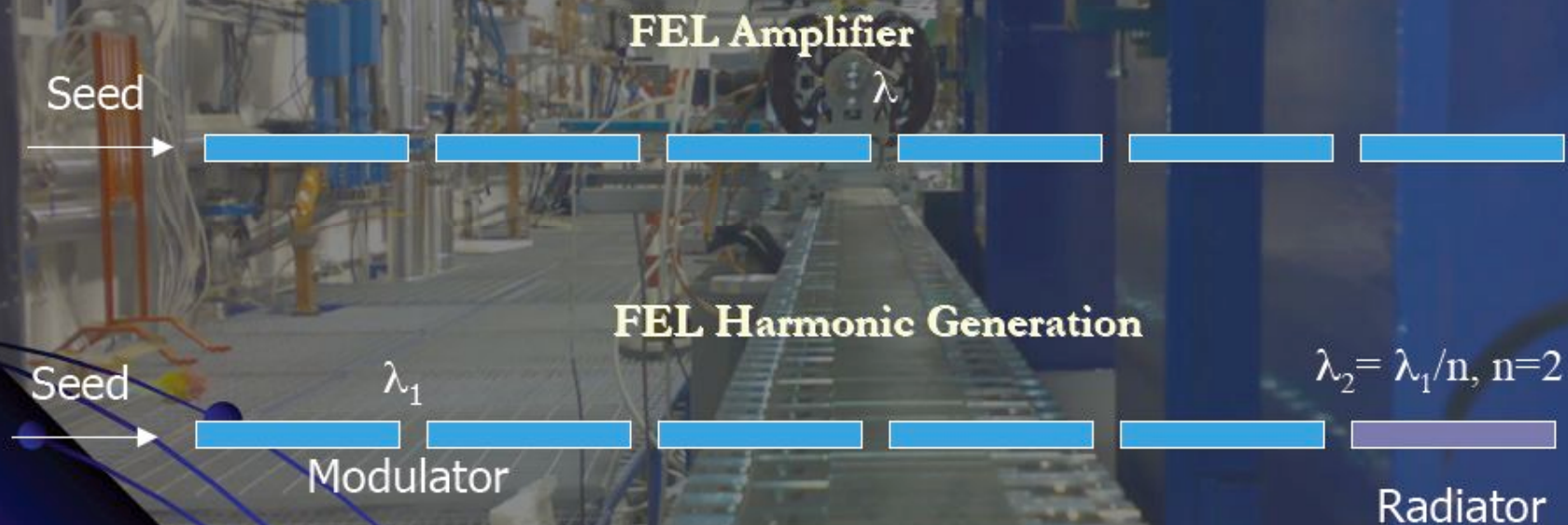
- 1) The seeding laser system is a regenerative amplifier, making use of a sample of the optical IR pulse train produced by the oscillator of the photocathode laser system. This makes the two lasers 100% time correlated.
- 2) The pulse of the laser oscillator are spaced by 12.6 ns (79.33 MHz). An optical delay line with a dynamic range > 12.6 ns allows shifting in time the 2 laser systems (and therefore the seed respect to the beam).



- 3) The trigger system allows to select the same pulse in the 2 laser systems for amplification .
- 4) A coarse (few ps) superposition of the beam and seed can be obtained by looking at the relative position of the pulses at the same target on a streak camera. SASE light (with seeding off) is the best candidate to identify the beam arrival time.
- 5) Fine tuning will be driven by observation and optimization of the seeding process.

2 days of beam

- 1° day - synchronization e-beam & laser
- 2° day - first seeding tests:

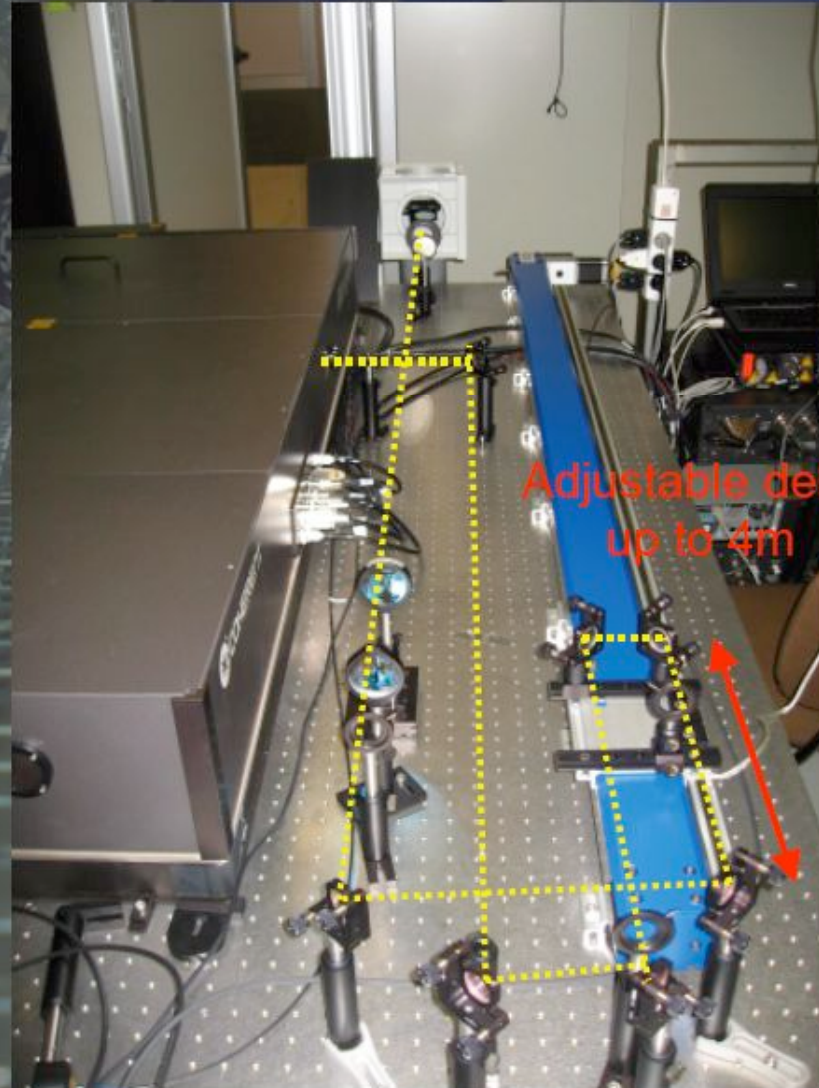


Very preliminary results

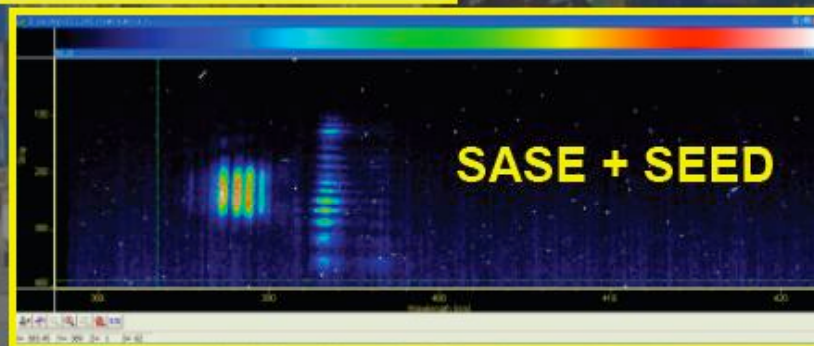
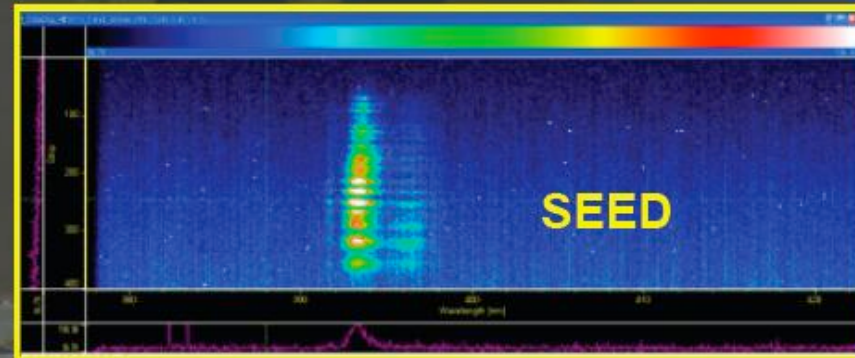
1° Day

Adjust delay line

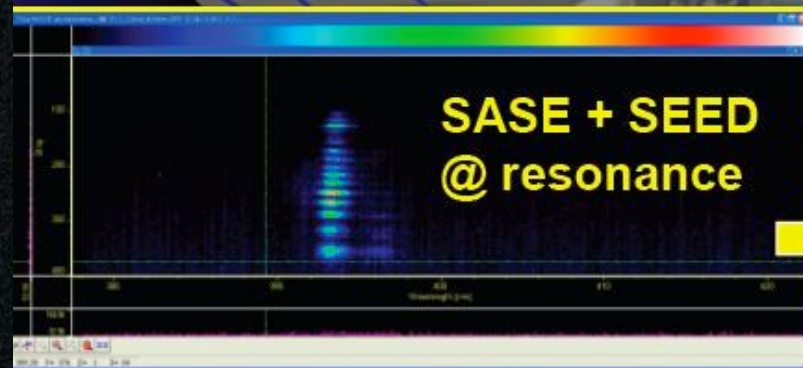
- Align seed to reference in UM (1.5 μJ)
- Tune resonance @400 nm
- Adjust electronic delay better than 1 ns (photodiode)
- Move the delay line until amplification is observed



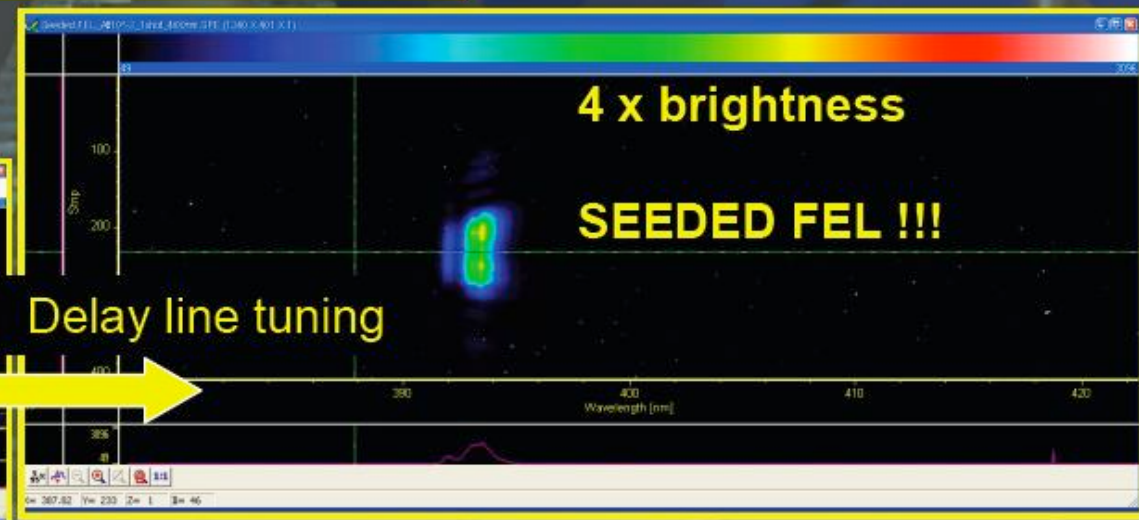
Synchronization (11-02-2010)



Beam energy tuning



Delay line tuning



2° Day

Seed



FEL Amplifier

λ



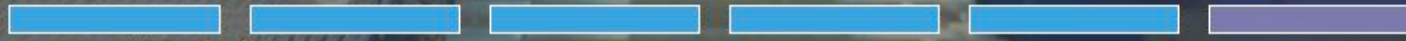
FEL Harmonic Generation

Seed



λ_1

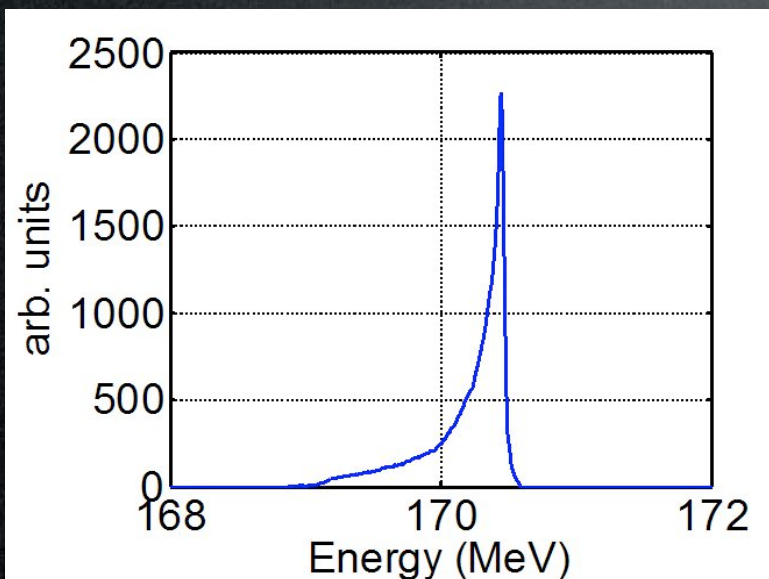
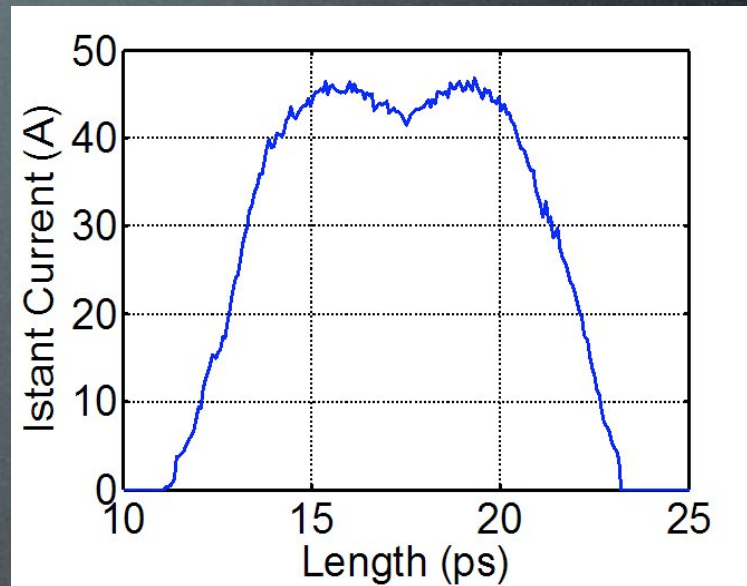
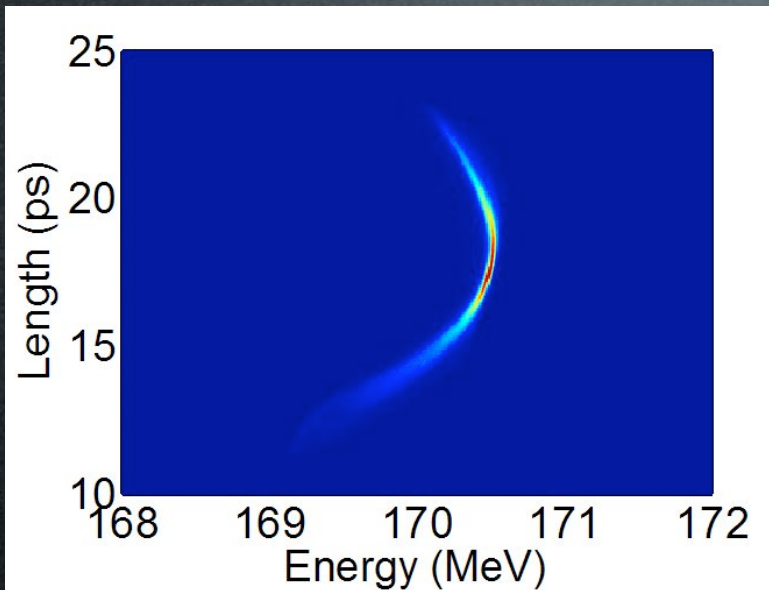
Modulator



$\lambda_2 = \lambda_1/n, n=2$

Radiator

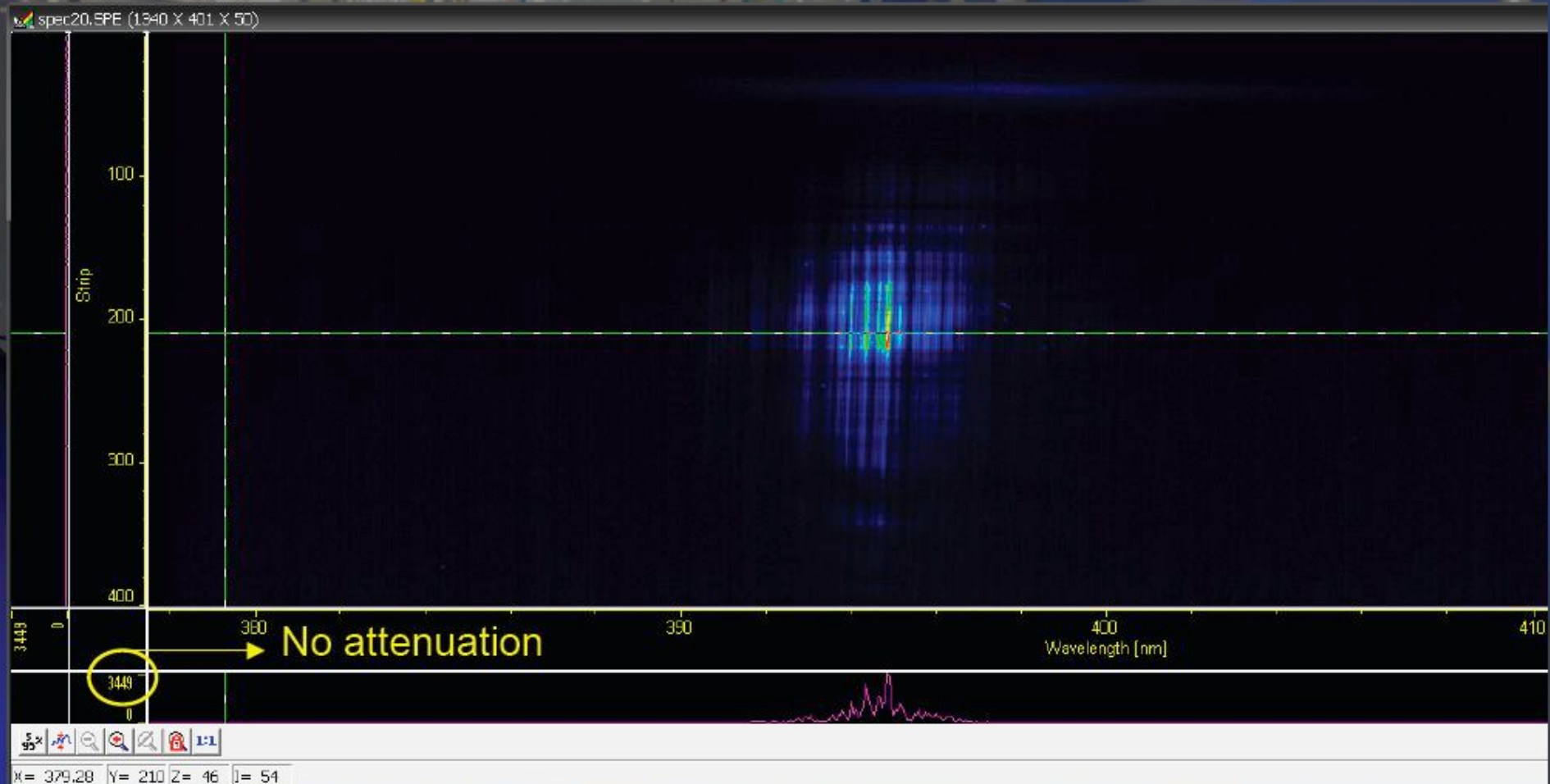
Beam parameters



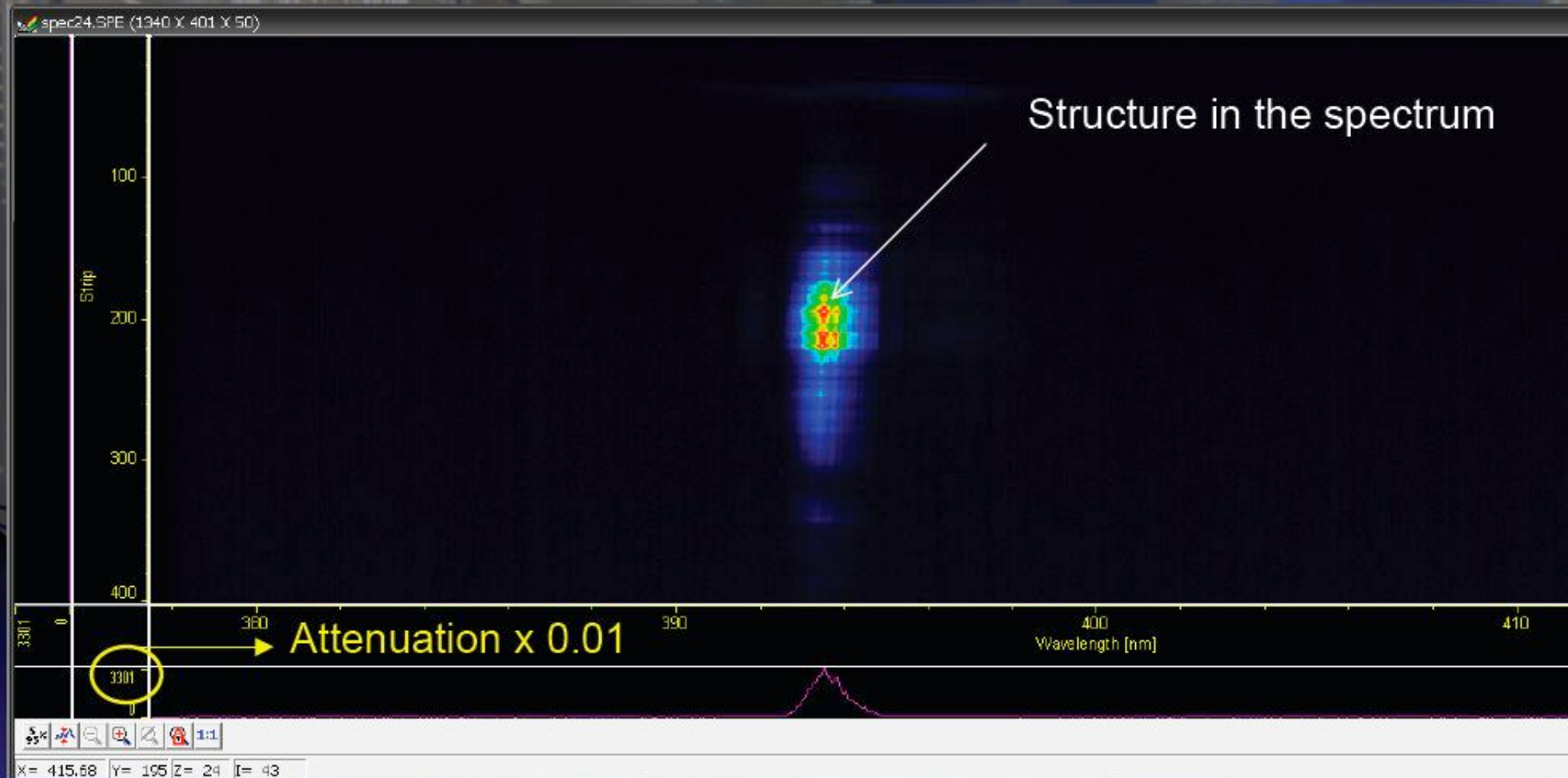
Beam parameters	
Emittance (mm-mrad)	3-4
Slice En.Spread ($\times 10^{-4}$)	2-3

SASE @ 400 nm

typical spectrum



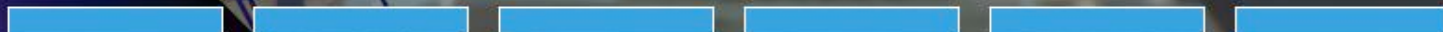
Seeded FEL



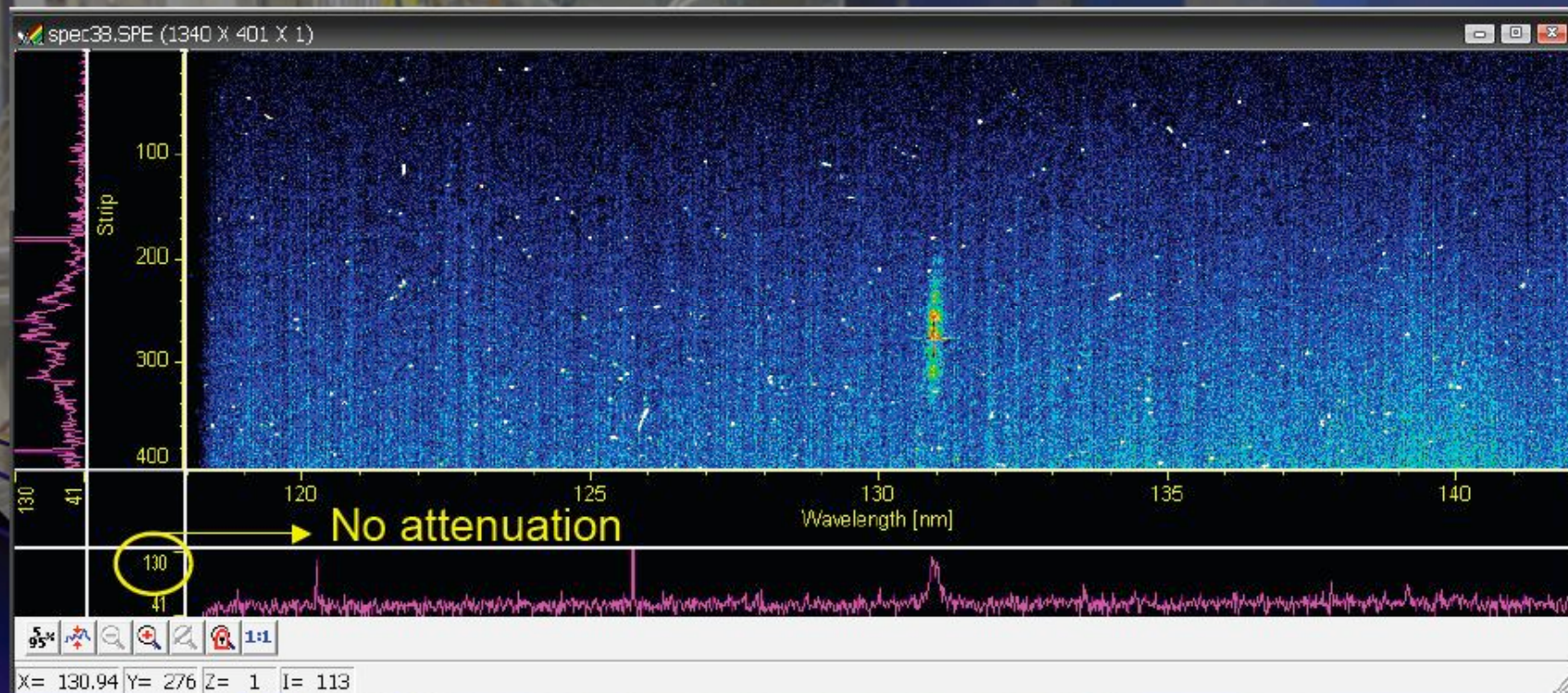
Seeded Amplifier

λ

Seed



3° harmonic



FEL Harmonic Generation

Seed

λ_1

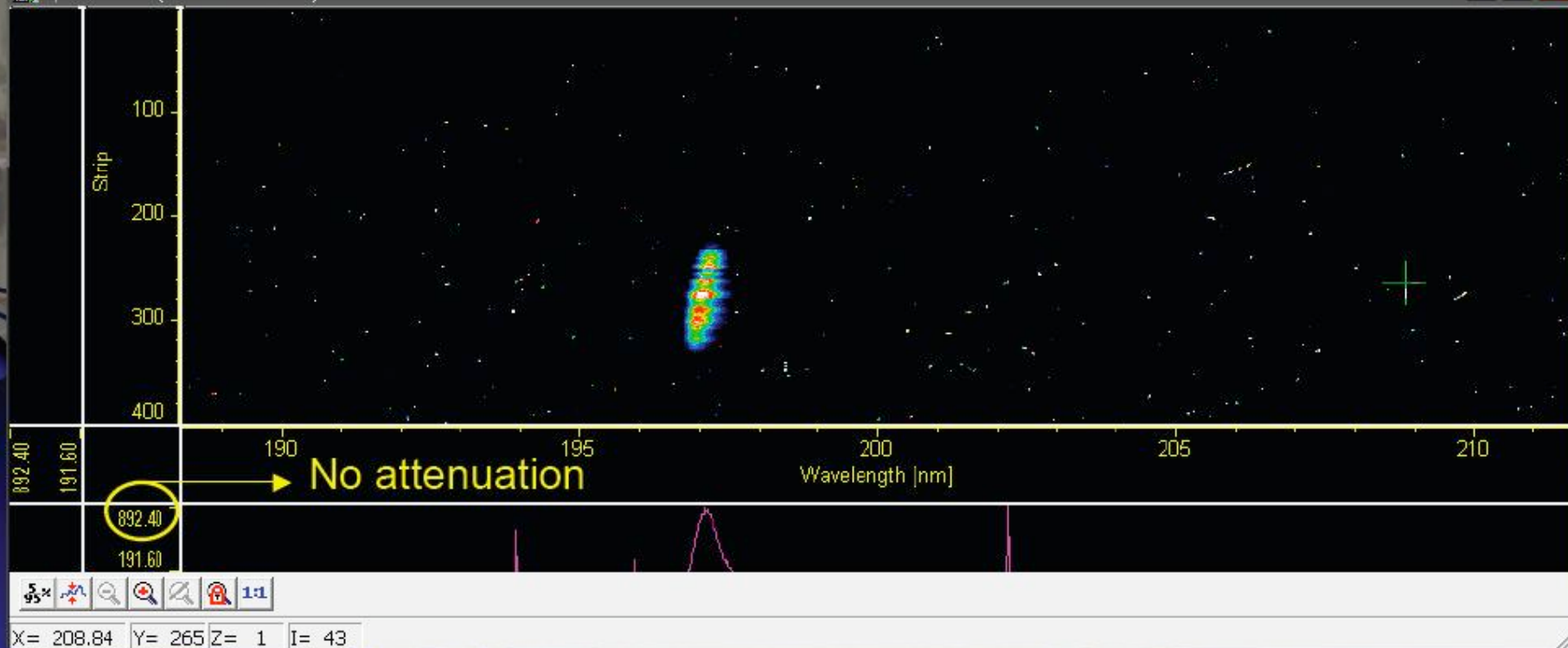
Modulator

$\lambda_2 = \lambda_1/n, n=2$

Radiator

200 nm

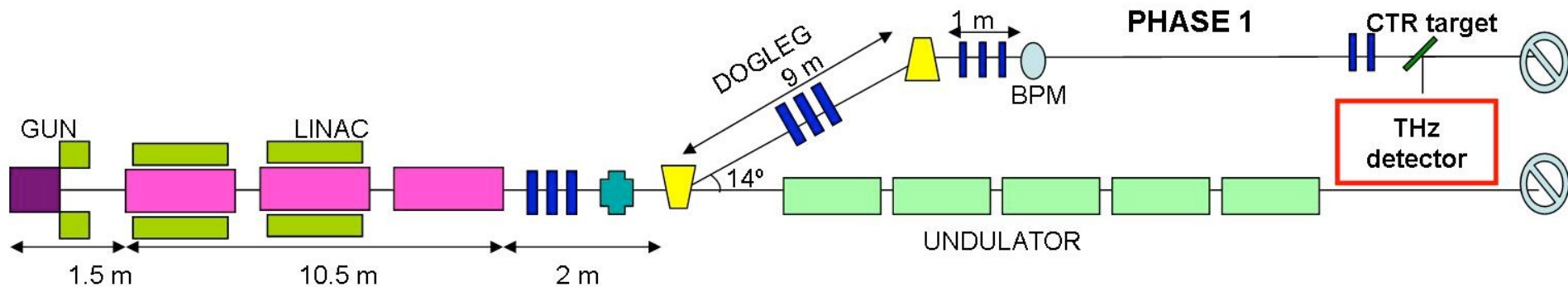
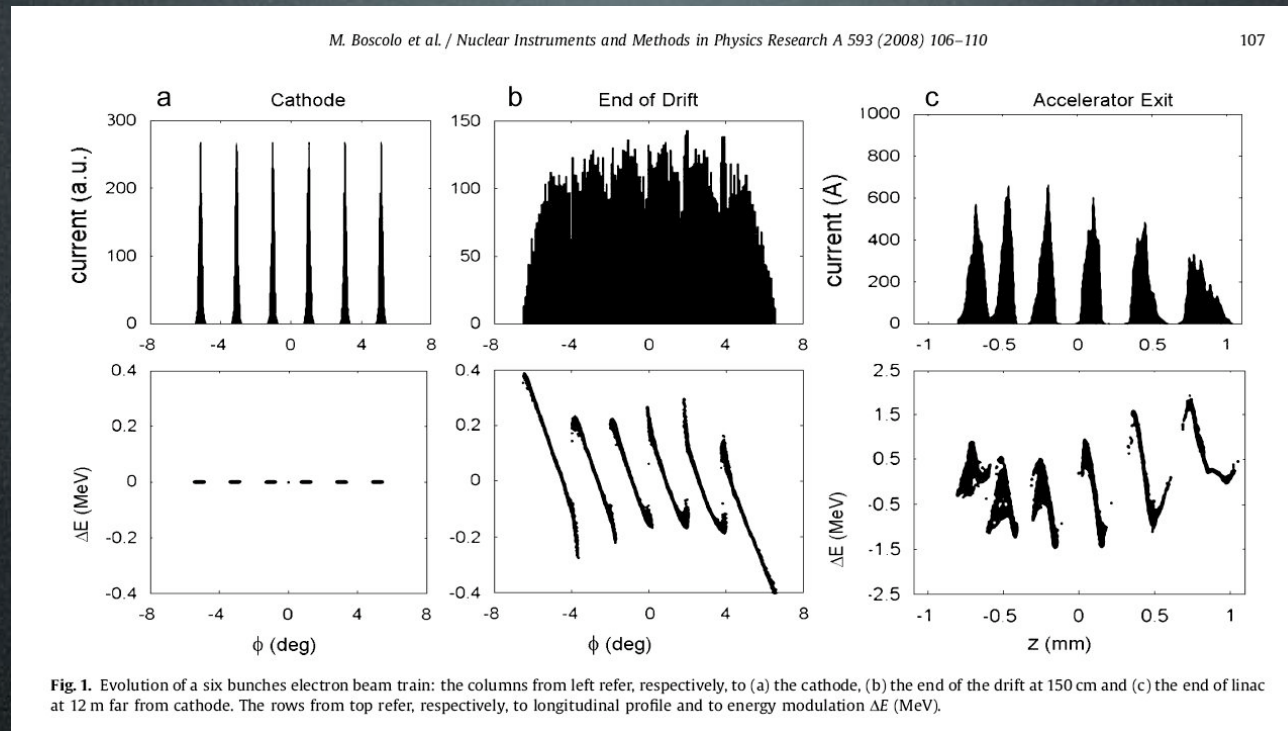
spec36.SPE (1340 X 401 X 50)



Laser Comb

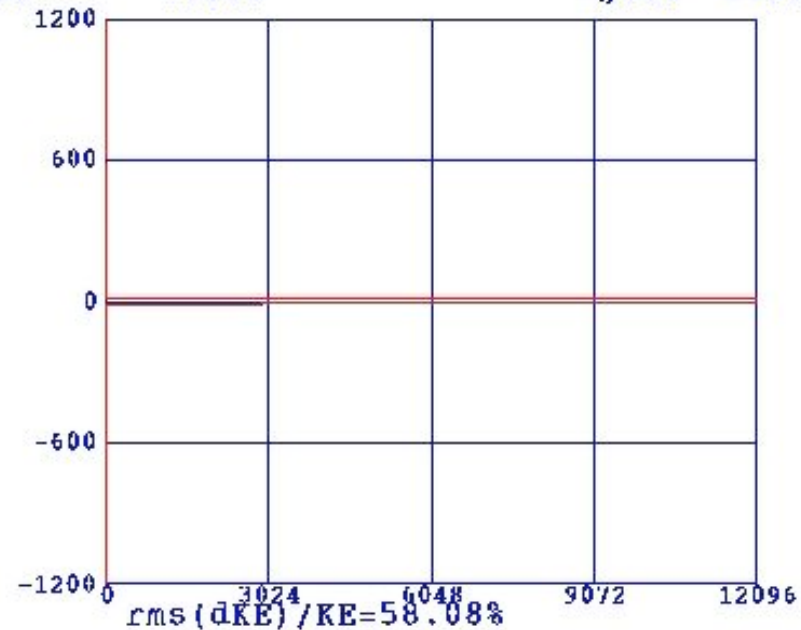
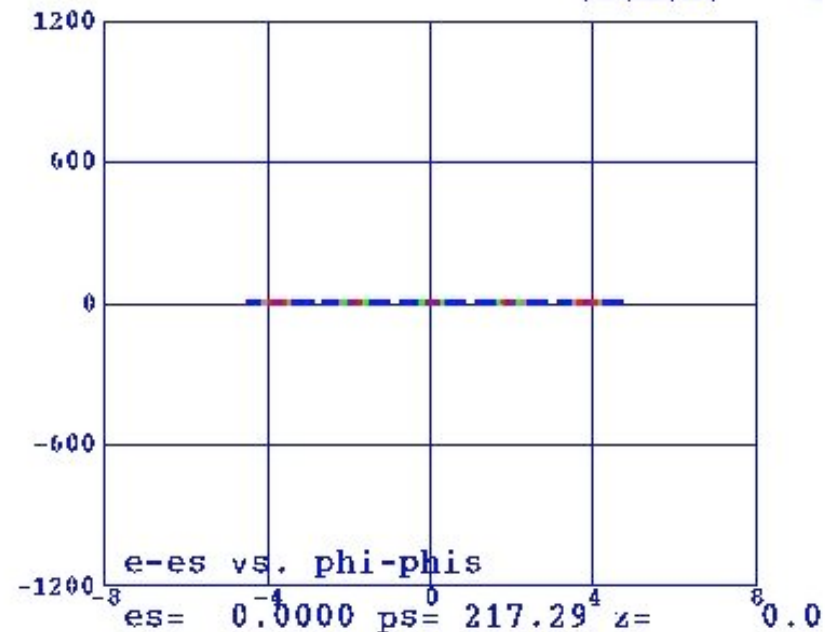
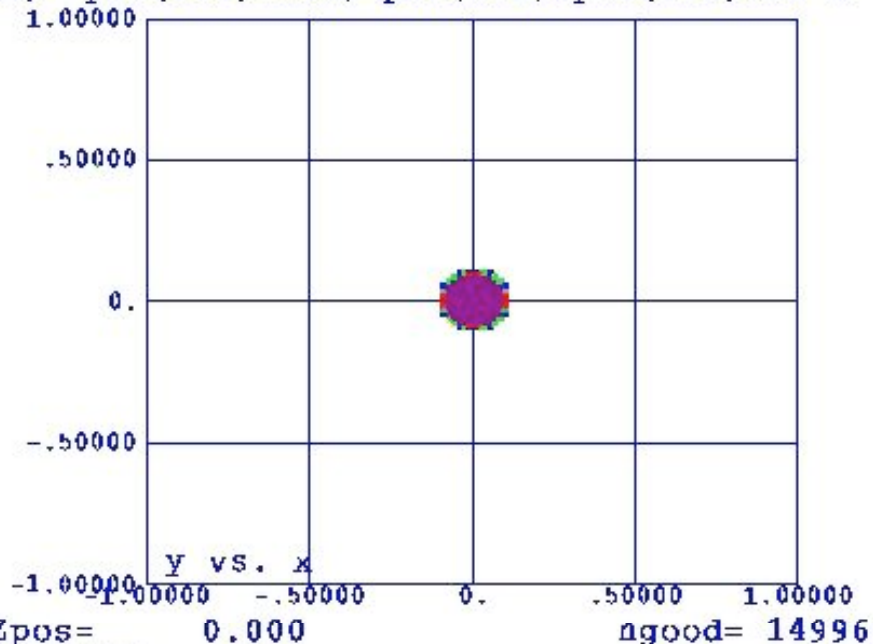
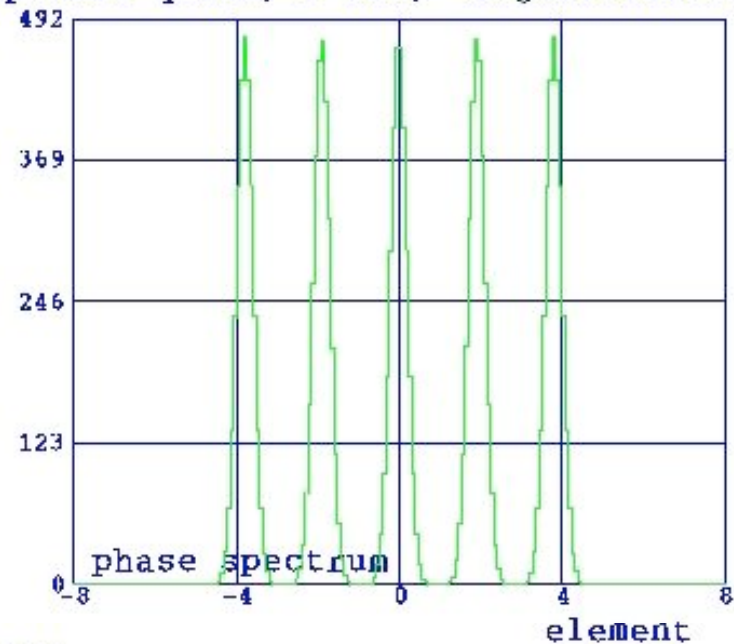
(Giant microbunch instability)

Laser Comb: a train of THz bunches

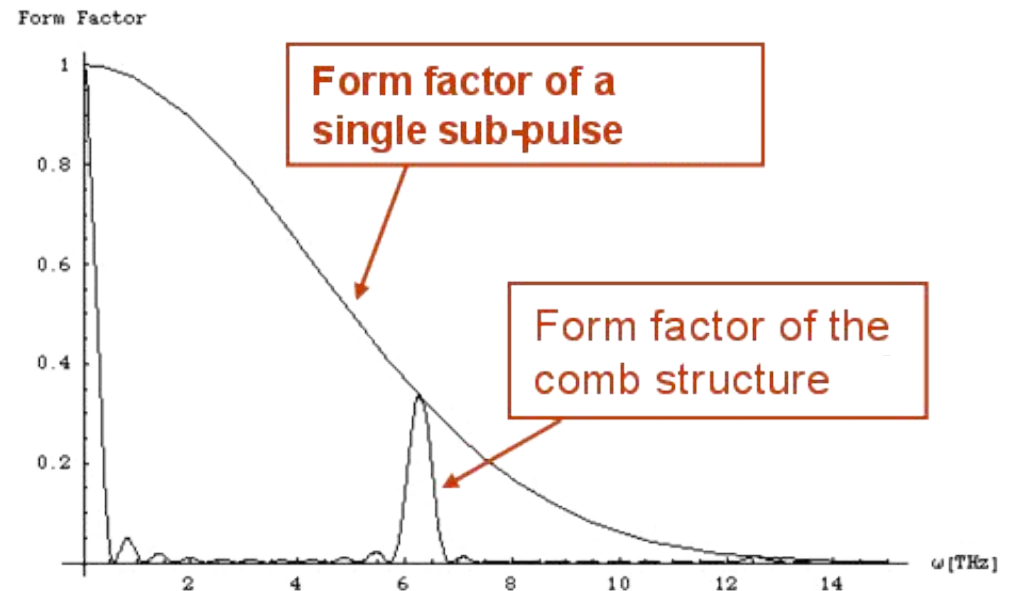
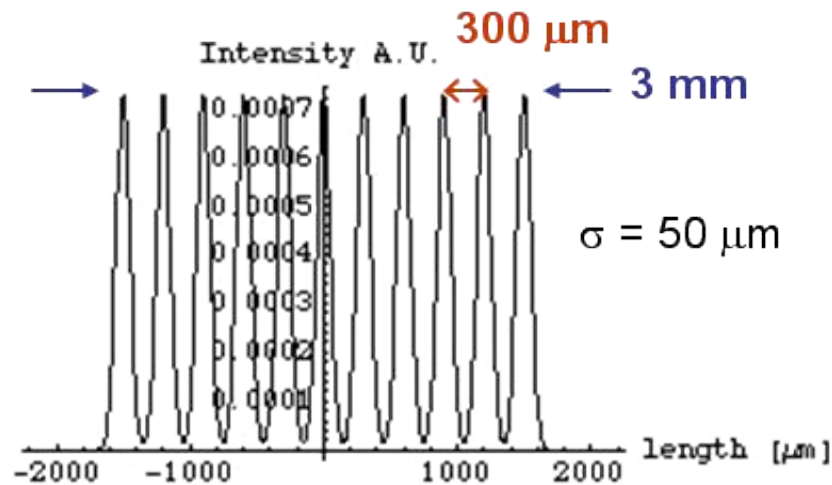


- P.O.Shea et al., Proc. of 2001 IEEE PAC, Chicago, USA (2001) p.704.
- M. Ferrario. M. Boscolo et al., Int. J. of Mod. Phys. B, 2006 (Taipei 05 Workshop)

4piccHI q=1nC; r=1mm; sigmat=300fs=0.3ps; phi(ITW)=-99; phi(2TW)=phi(2TW)=on c



THz source



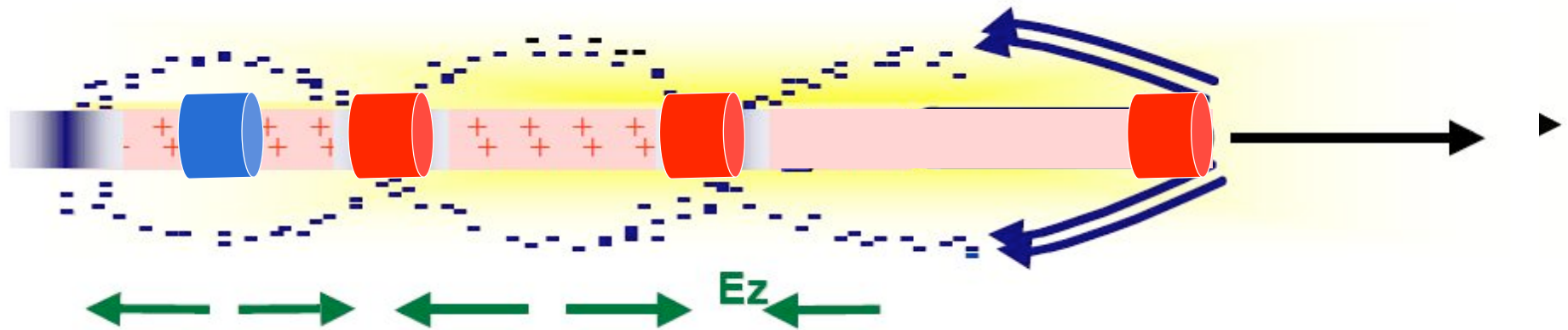
THz radiation can be easily produce by means of CTR

It is difficult to put high charge in sub-ps bunches

A laser comb structure in the longitudinal laser profile can solve this problem

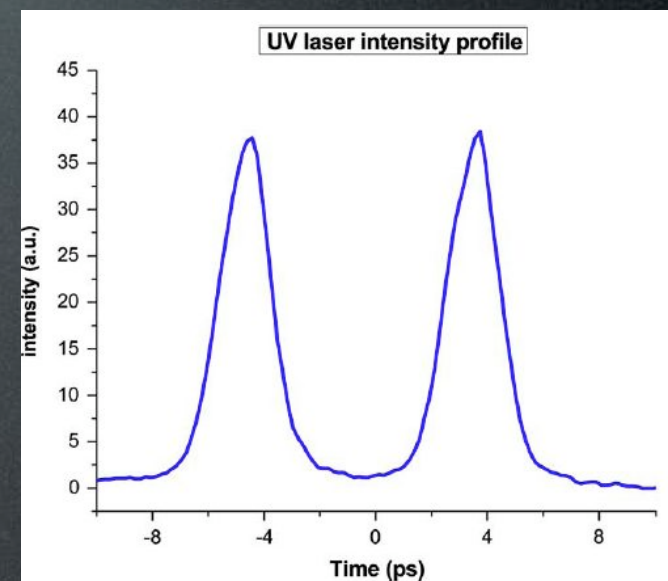
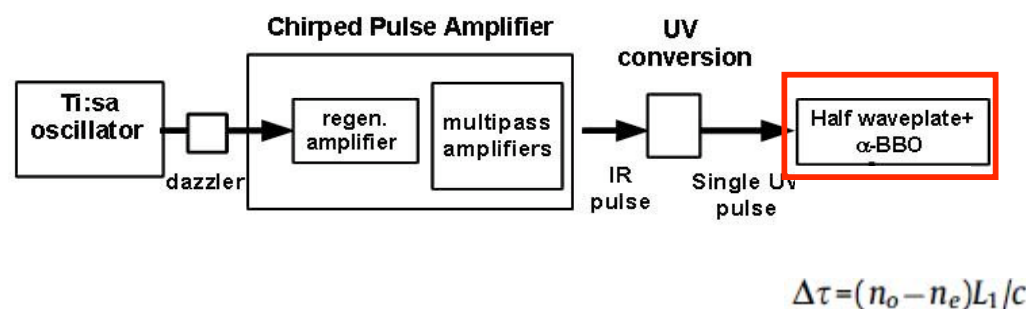
Plasma wakefield coherent excitation

- Space charge of drive beam displaces plasma electrons



- Plasma ions exert restoring force => Space charge oscillations

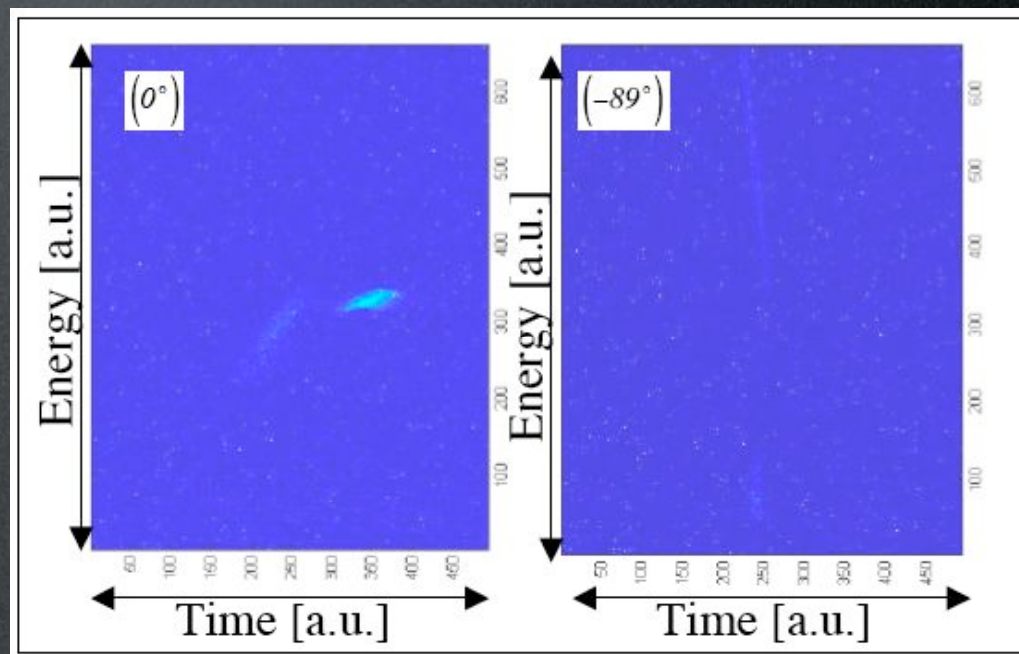
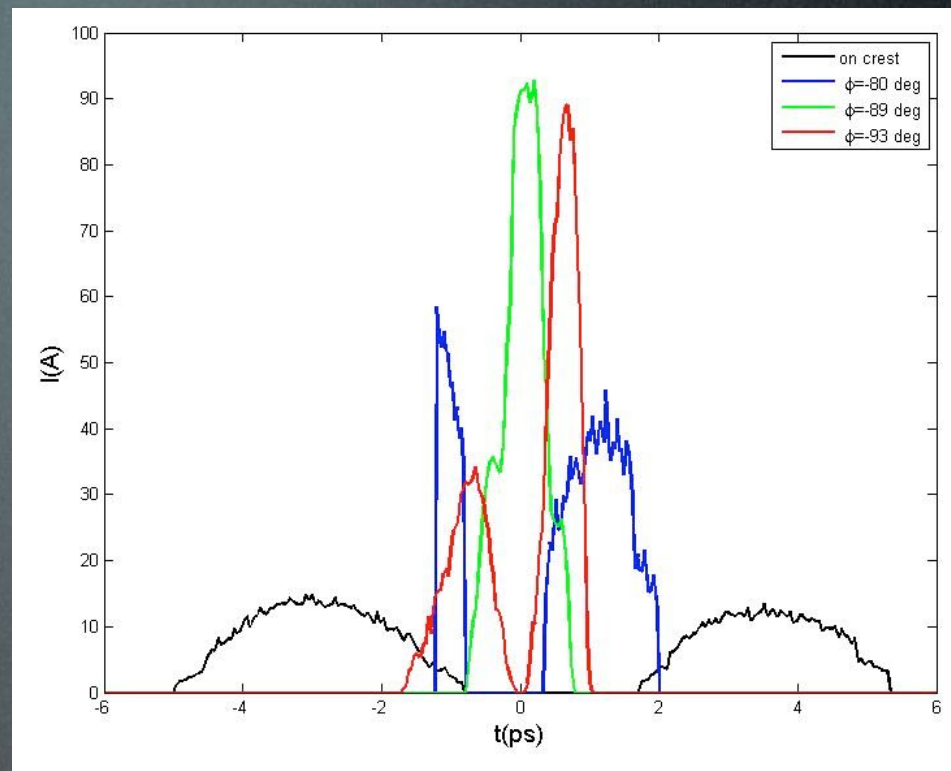
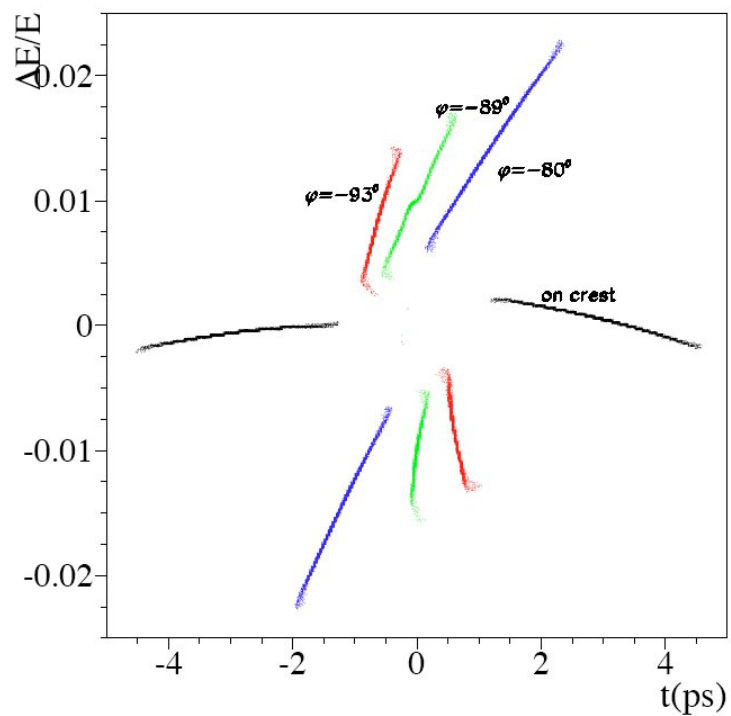
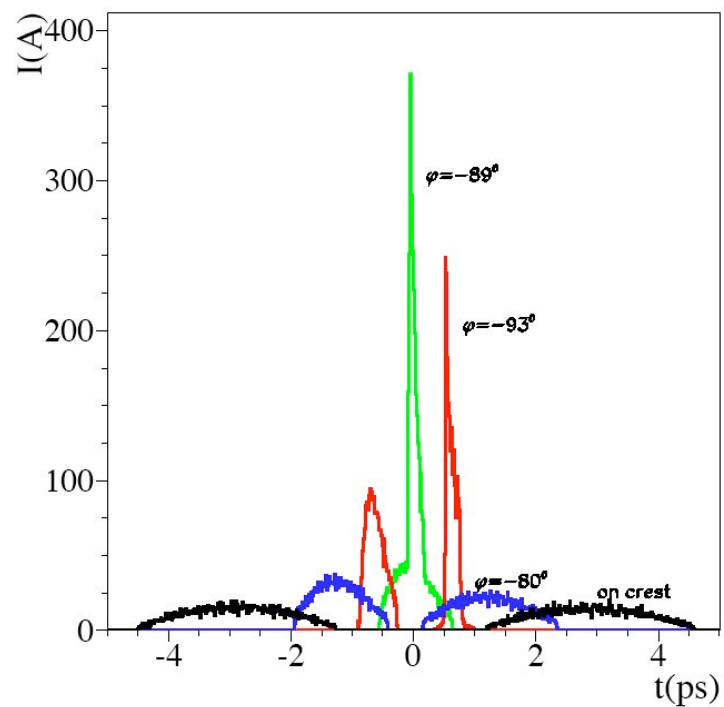
Laser comb with velocity bunching: Preliminary results at SPARC



35 pC/pulse

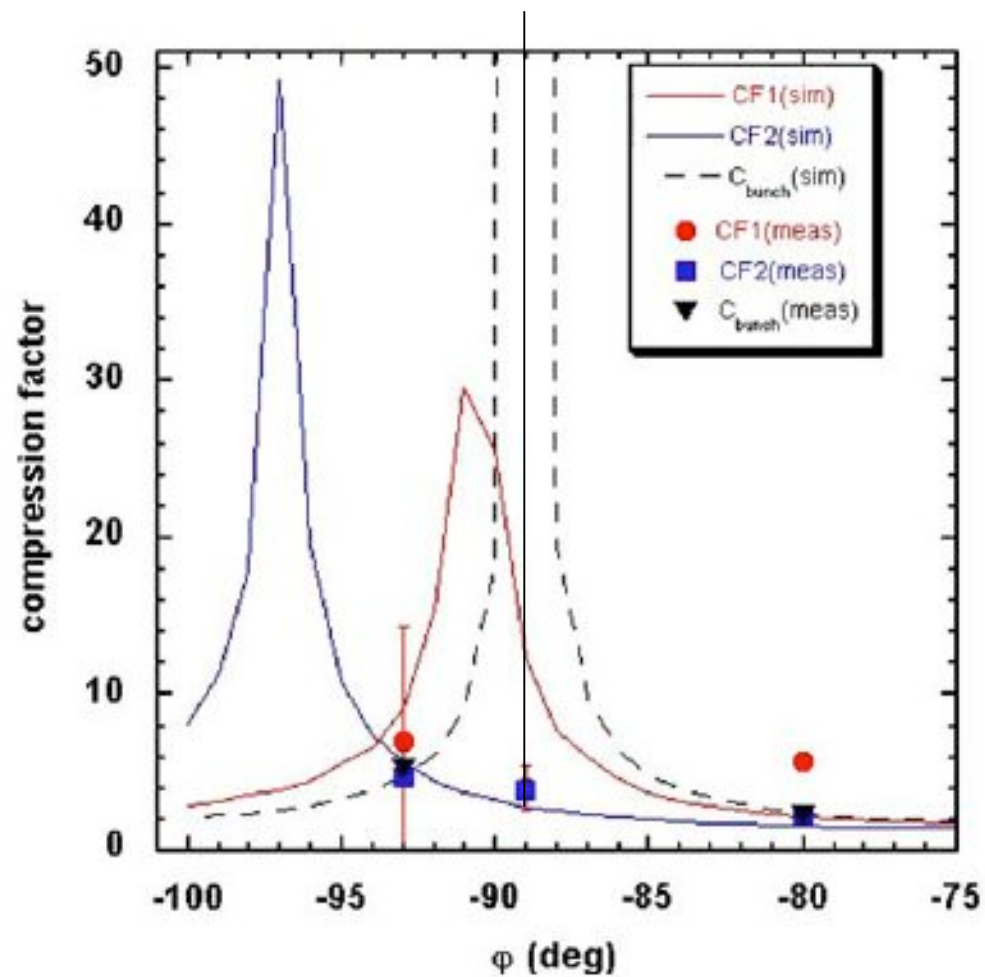
The technique used for this purpose relies on a birefringent crystal, where the input pulse is decomposed in two orthogonally polarized pulses with a time separation proportional to the crystal length.

The crystal thickness is 10.353 mm

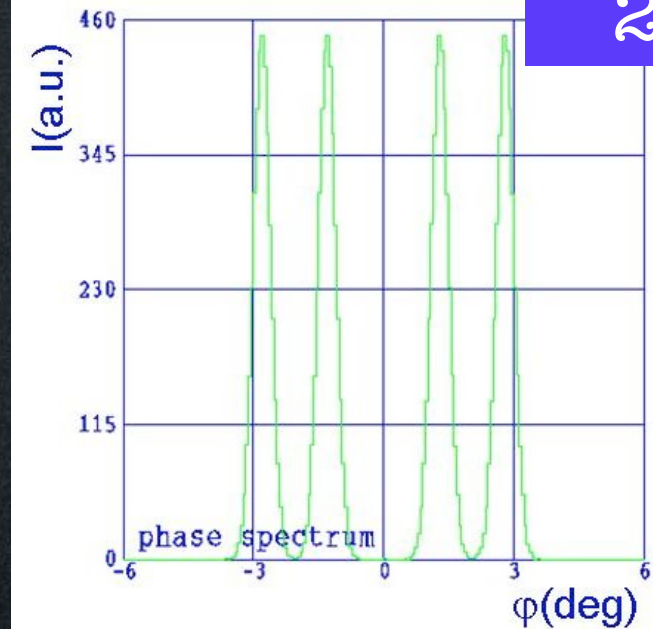


Measured pulse length [ps].

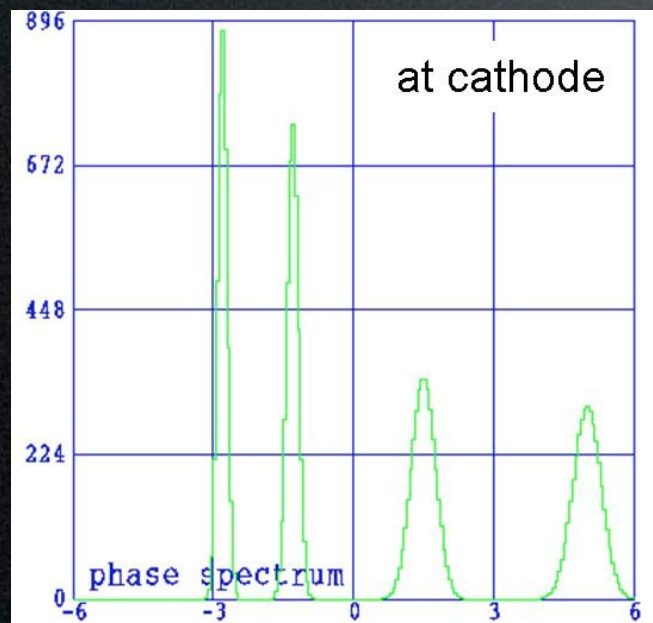
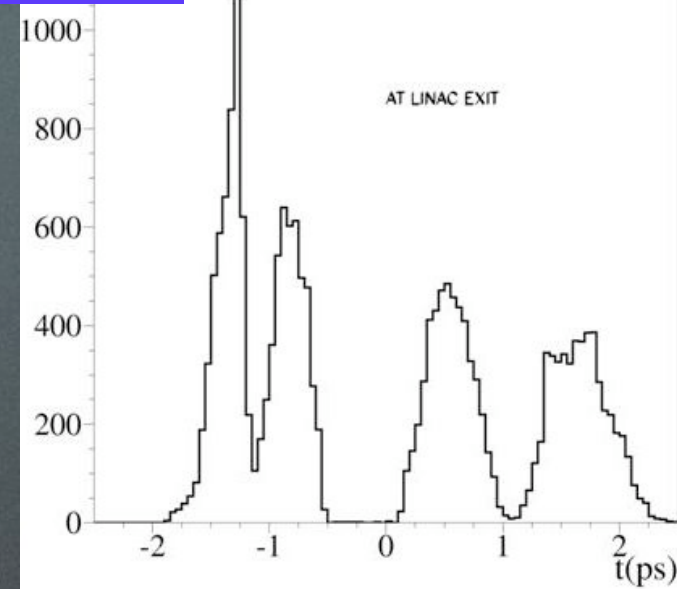
Phase	Trailing pulse	Leading pulse	Pulse distance
0°	0.73 ± 0.01	0.83 ± 0.04	6.50 ± 0.02
-80°	0.13 ± 0.01	0.40 ± 0.01	2.79 ± 0.24
-89°	0.19 ± 0.07	0.22 ± 0.02	Overlapped
-93°	0.11 ± 0.11	0.17 ± 0.02	1.24 ± 0.24



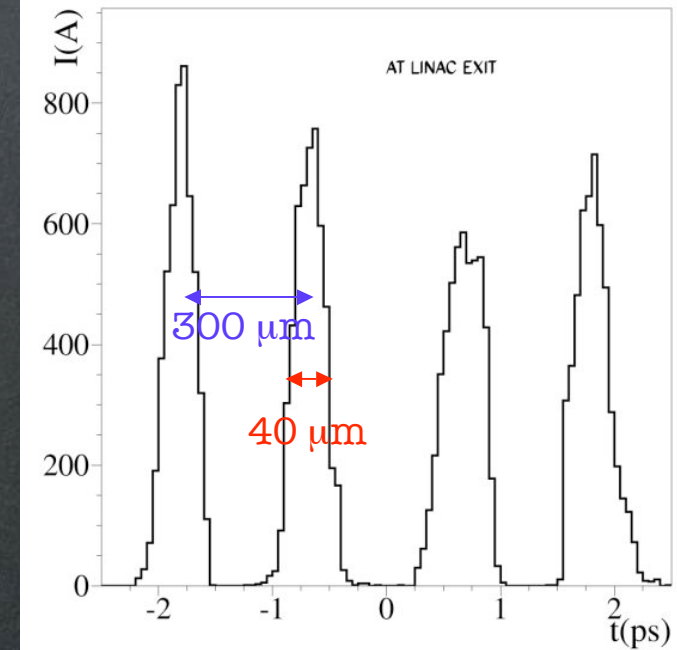
250 pC/pulse



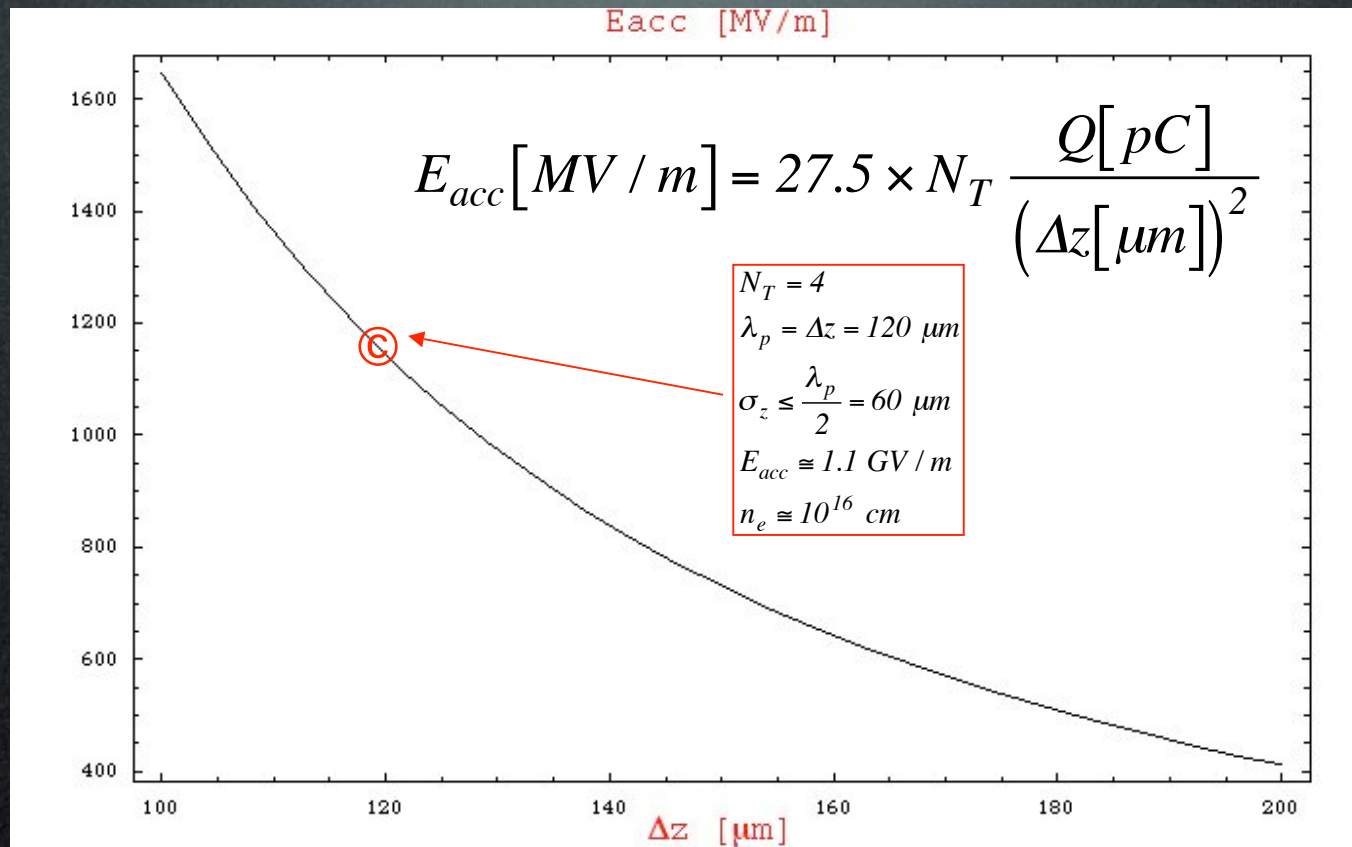
$\Rightarrow$



$\Rightarrow$

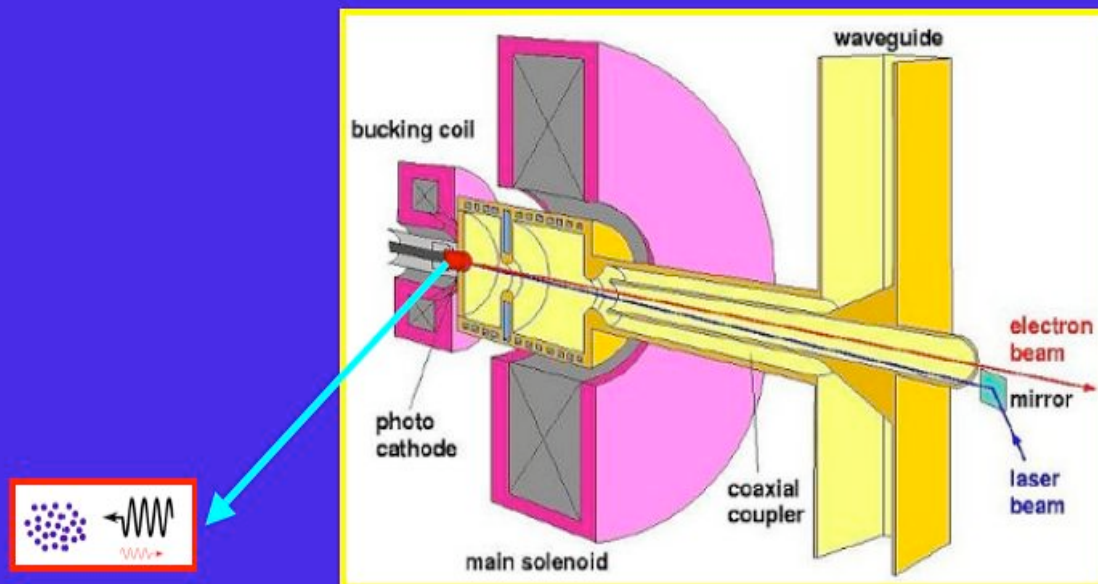


PWFA ==> 150 pC/pulse x 4 pulses



200 MeV in 18 cm

Electron-Laser interaction near the cathode



$$\lambda = 266 \text{ nm} \implies T = 8.9 \cdot 10^{-16} \text{ sec}$$

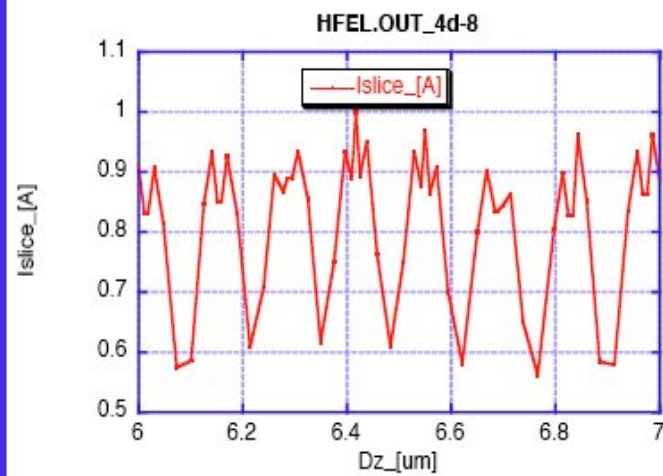
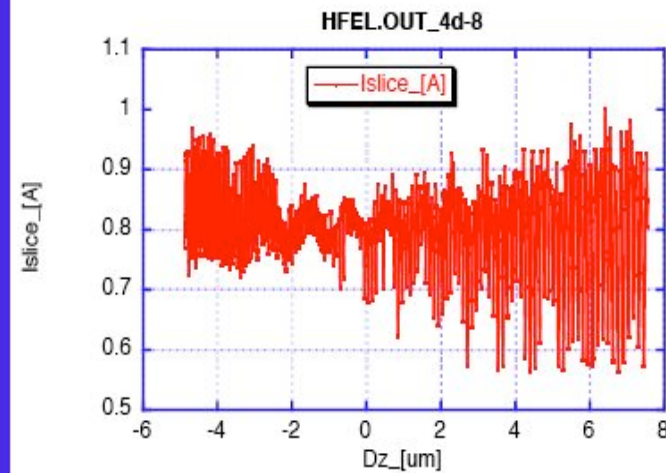
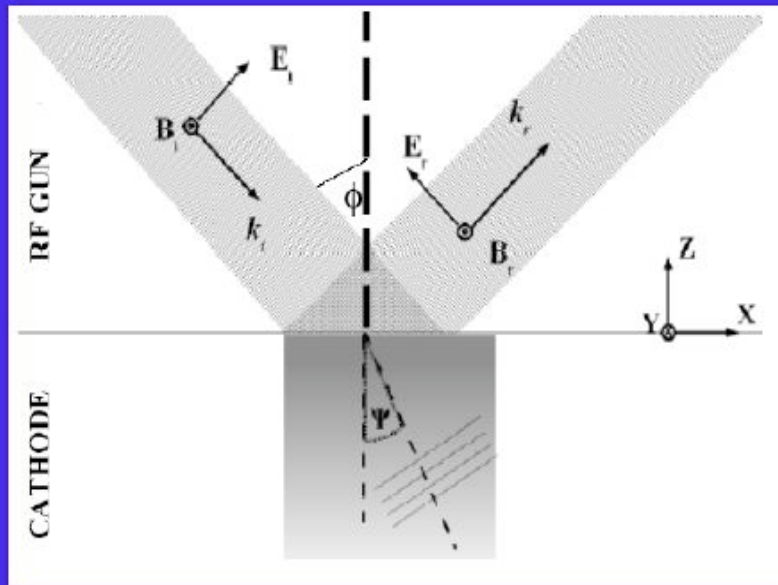
ELECTRON BEAM-LASER INTERACTION NEAR THE CATHODE IN A HIGH BRIGHTNESS PHOTOINJECTOR

M. Ferrario, G. Gatti, INFN-LNF, Frascati, Italy; L. Serafini, INFN-Mi, Milano, Italy;
J. B. Rosenzweig, UCLA, Los Angeles, USA

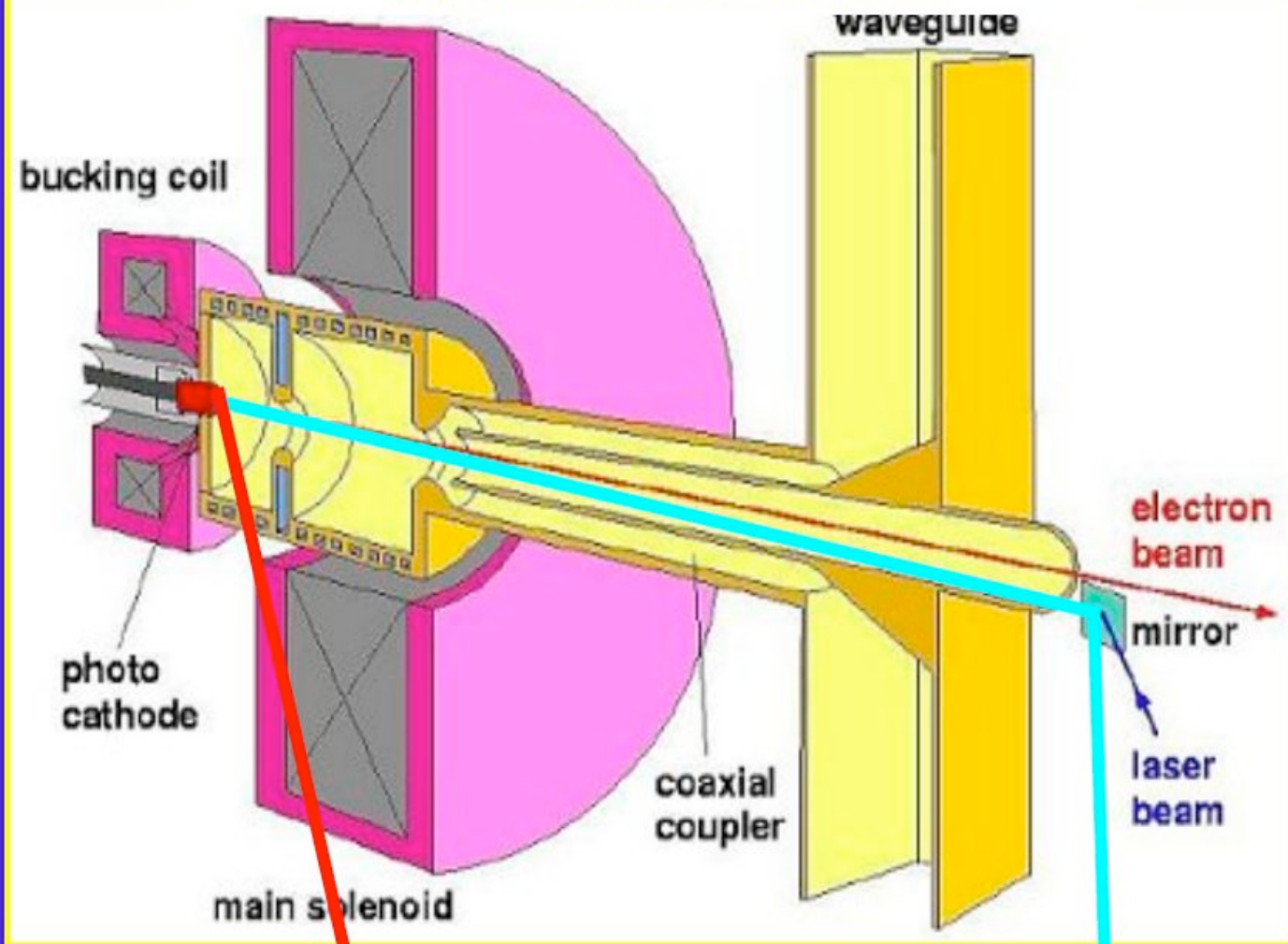
70° illumination

$\Rightarrow E_z = 180 \text{ MV/m}$

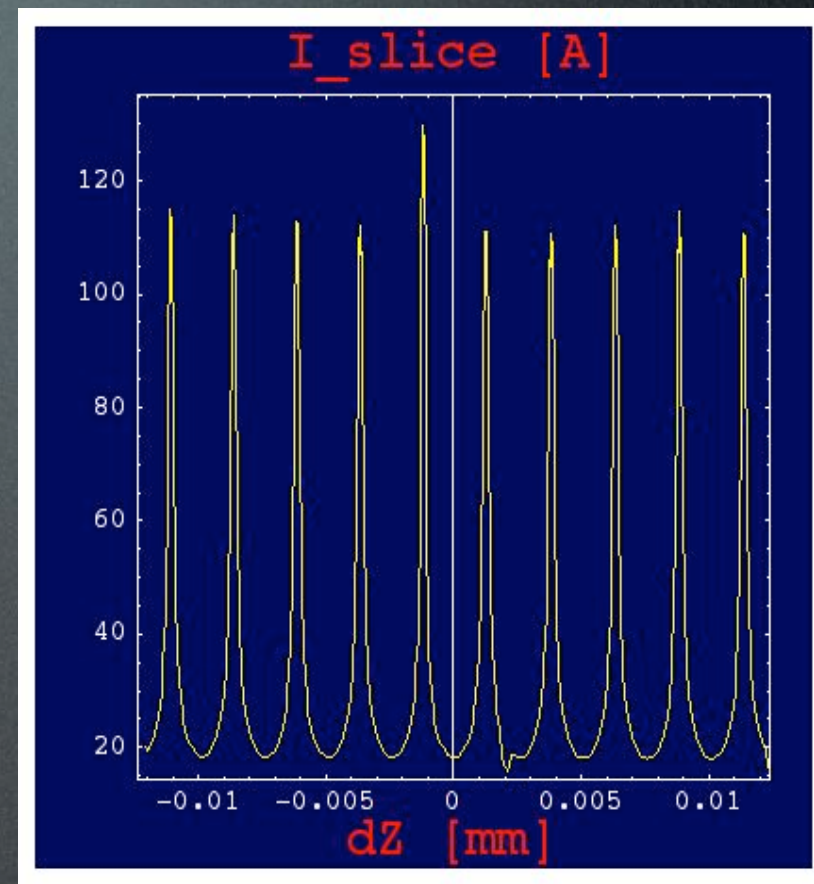
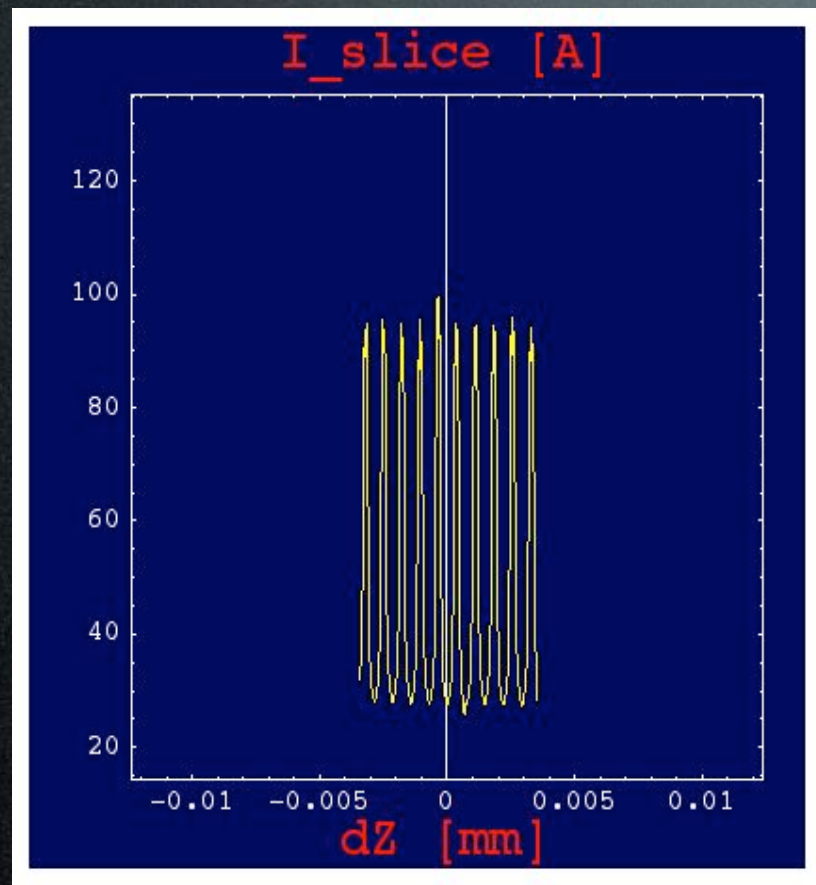
Microbunching at λ scale



LASER CONDITIONING

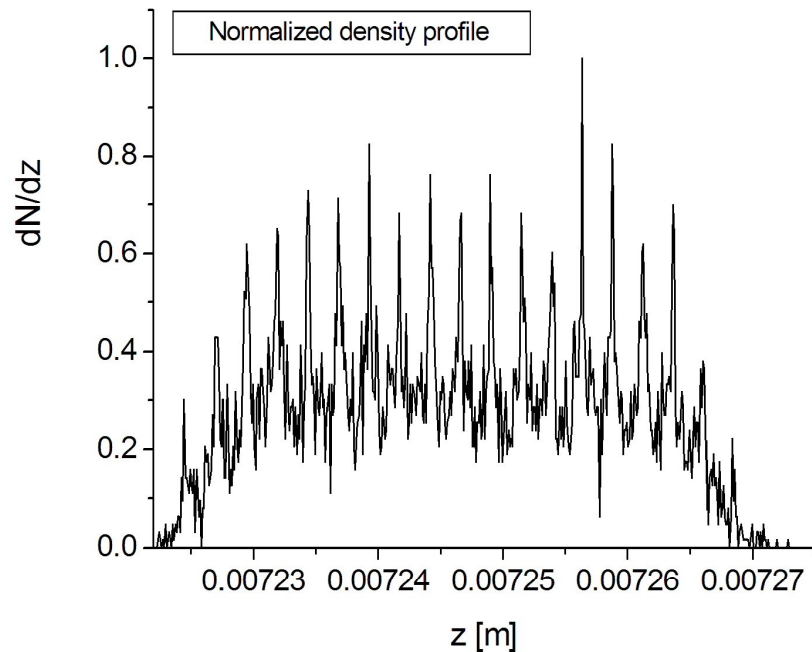
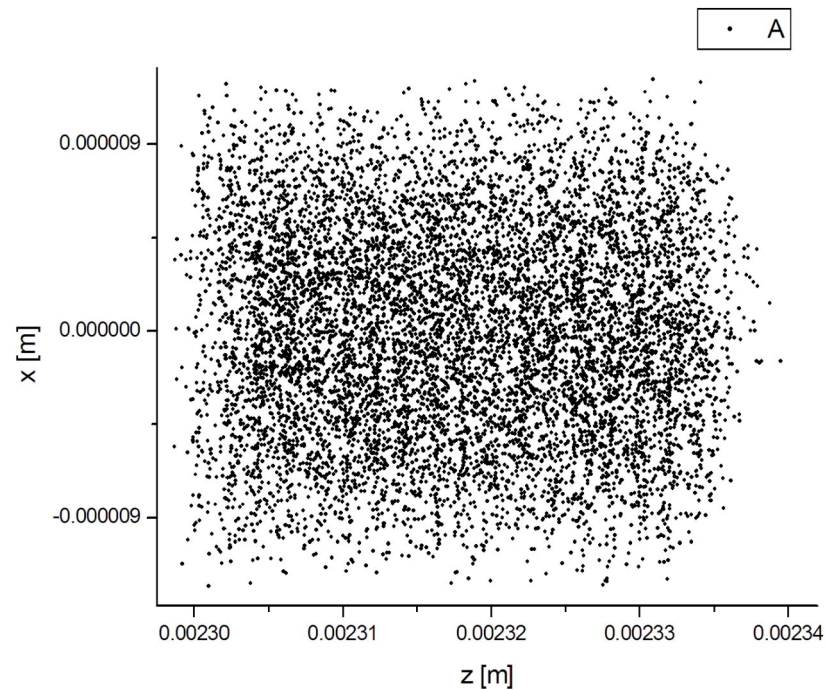


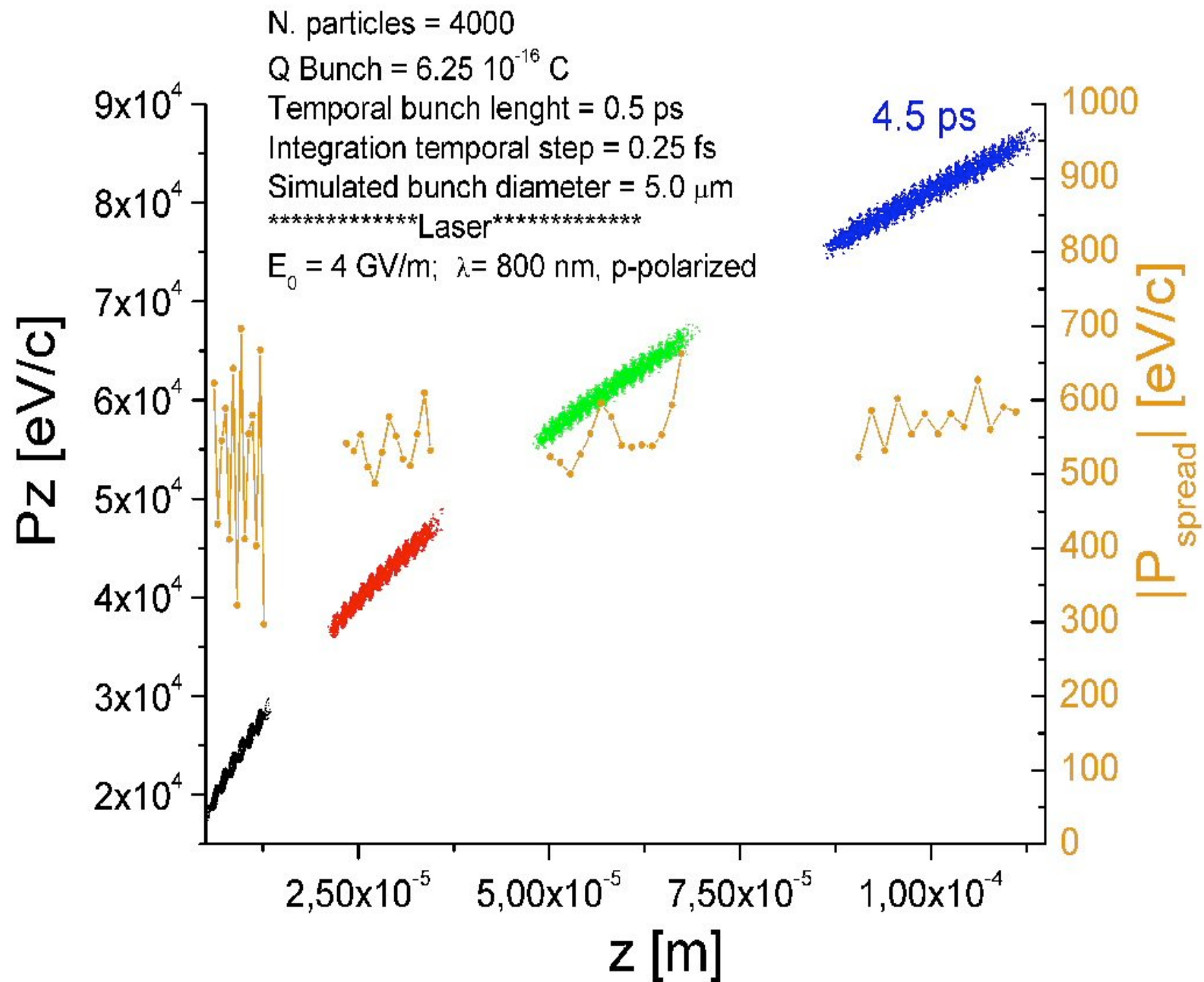
LASER

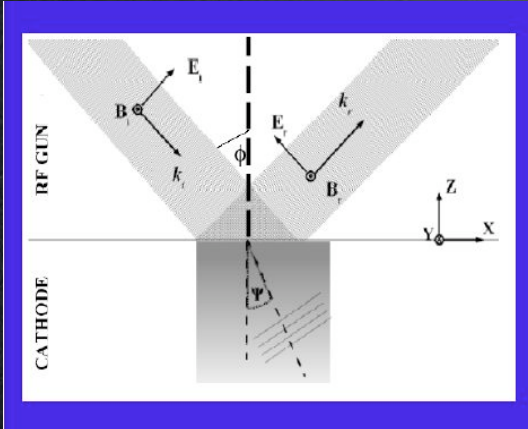


A. Bacci - RETAR

Laser IR 0.8 micron
 $E_0 = 500 \text{ MV/m @ } 72 \text{ Deg}$
Bunch radius = 5 micron
Laser pulse length = 2 ps
Injection phase = 29.1 Deg







Setting

$$E_z = E_0 [1 - \alpha \sin(\phi)]$$

where $\alpha = \frac{E_0 \sin(\theta)}{E_{\text{laser}}}$ and $\phi = \omega t + \frac{\omega \cos \theta}{c} z(t)$, the relative equation of motion reads:

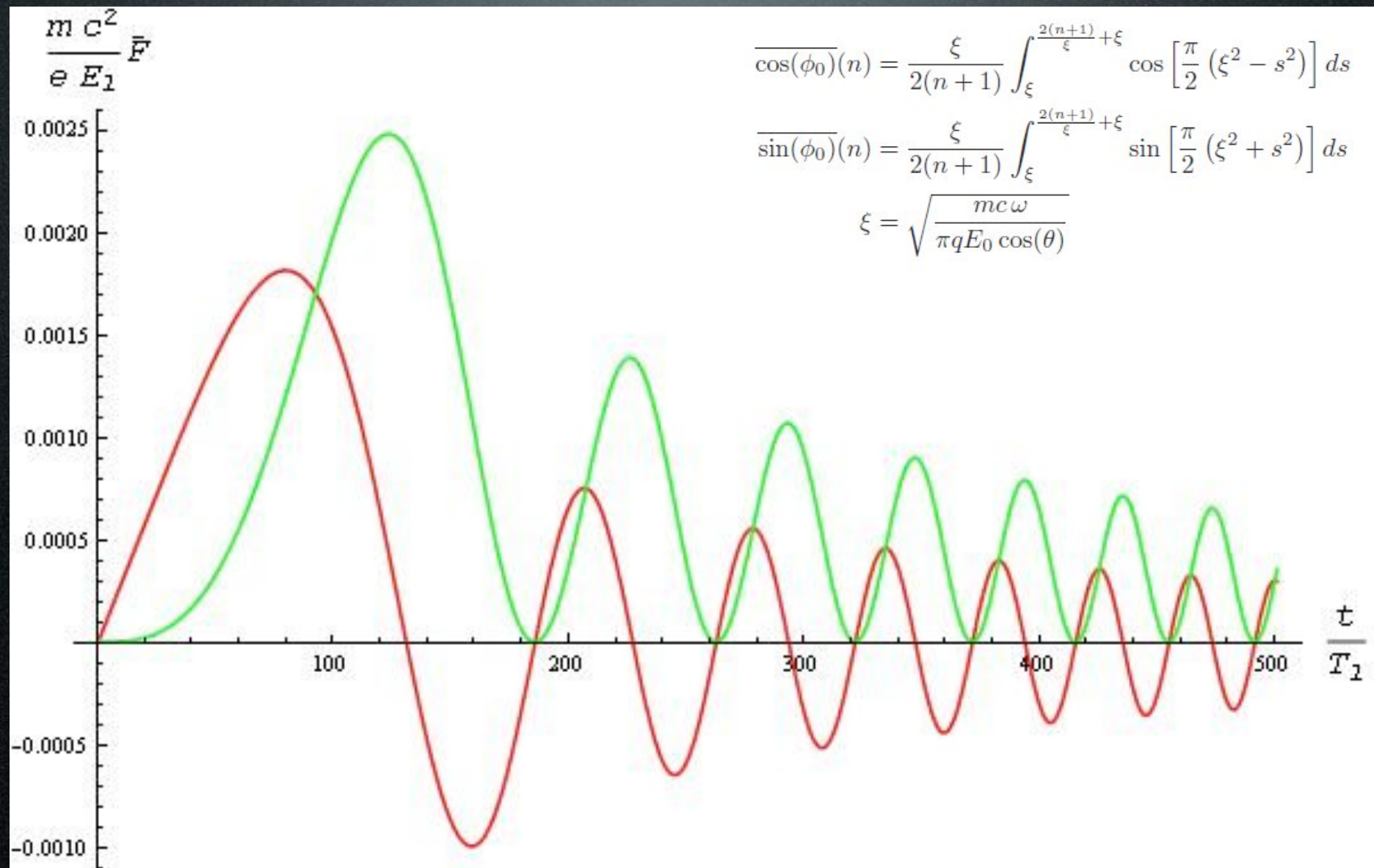
$$\frac{1}{mc^2} \frac{d}{dz} (\Delta E_T) = \frac{qE_0 \alpha}{mc^2} [\sin(\phi_0 + \Delta\phi) - \sin(\phi_0)]$$

$$E_z = E_0 [1 - \alpha \sin(\phi)]$$

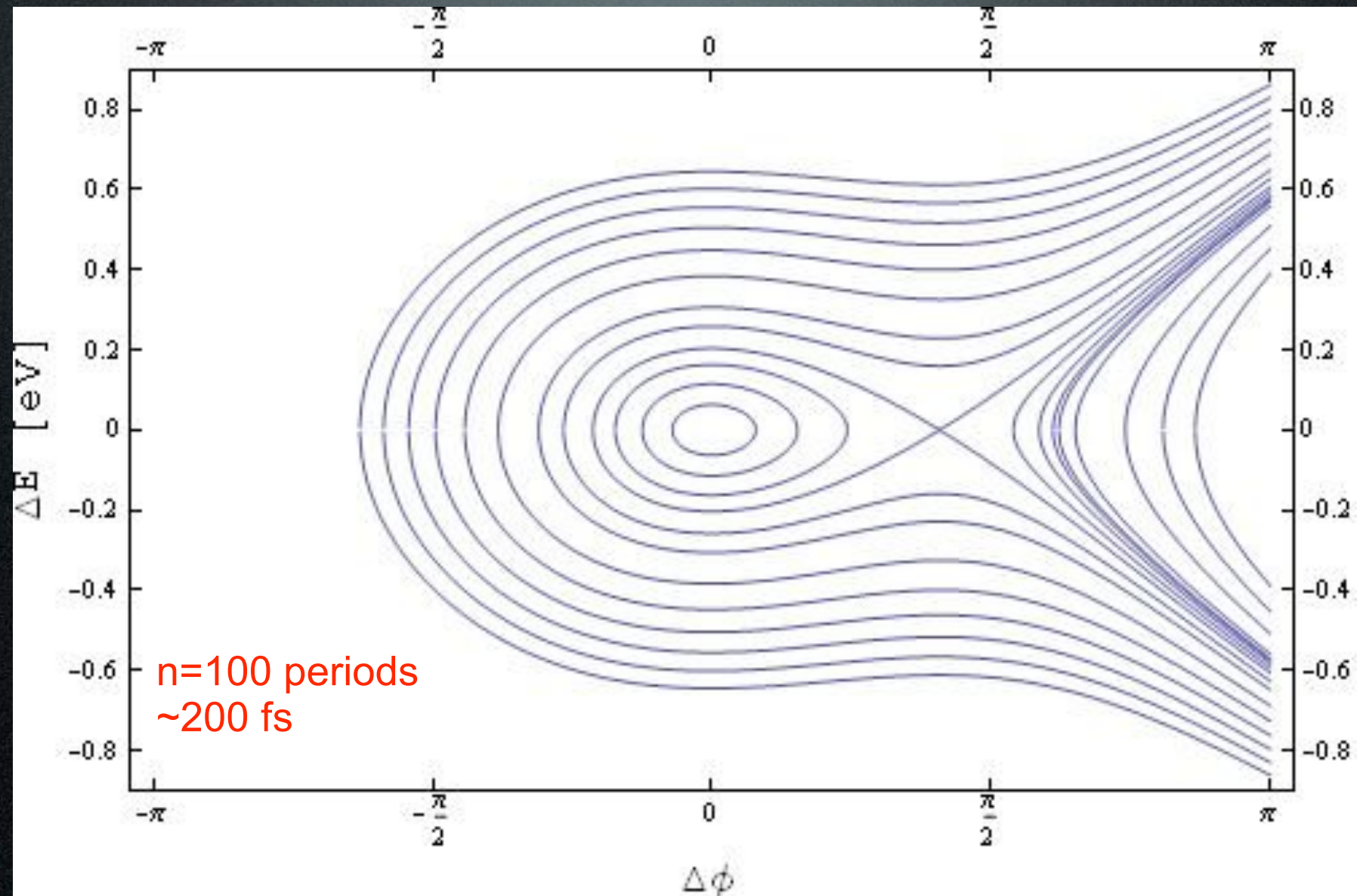
where $\alpha = \frac{E_0 \sin(\theta)}{E_{\text{laser}}}$ and $\phi = \omega t + \frac{\omega \cos \theta}{c} z(t)$, the relative equation of motion reads:

$$\frac{1}{mc^2} \frac{d}{dz} (\Delta E_T) = \frac{qE_0\alpha}{mc^2} [\sin(\phi_0 + \Delta\phi) - \sin(\phi_0)]$$

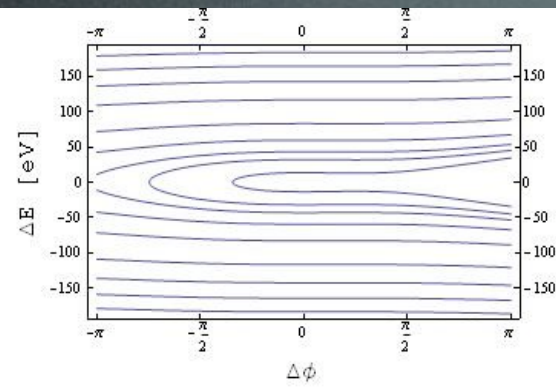
$$(\Delta E_T)^2 = -2mc^3 \frac{\beta_0^3 \gamma_0^3}{\omega} qE_0 \alpha \sin(\theta) \left\{ \overline{\sin(\phi_0)}(n) [\sin(\Delta\phi) - \Delta\phi] - \overline{\cos(\phi_0)}(n) \cos(\Delta\phi) \right\} + C$$



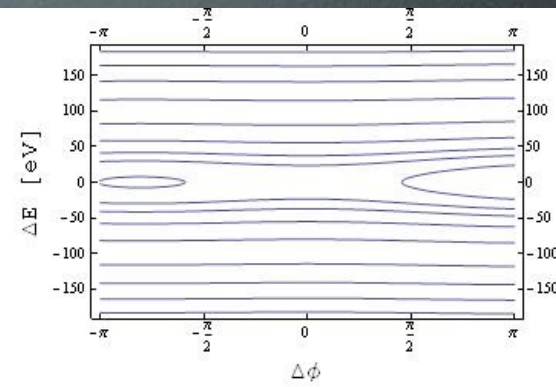
$$(\Delta E_T)^2 = -2mc^3 \frac{\beta_0^3 \gamma_0^3}{\omega} q E_0 \alpha \sin(\theta) \left\{ \overline{\sin(\phi_0)}(n) [\sin(\Delta\phi) - \Delta\phi] - \overline{\cos(\phi_0)}(n) \cos(\Delta\phi) \right\} + C$$



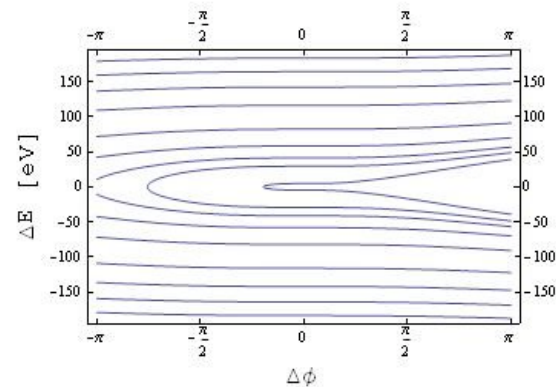
n=5000



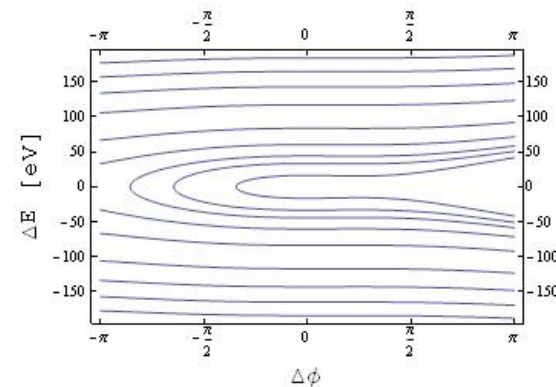
n=5001



n=5002



n=5003



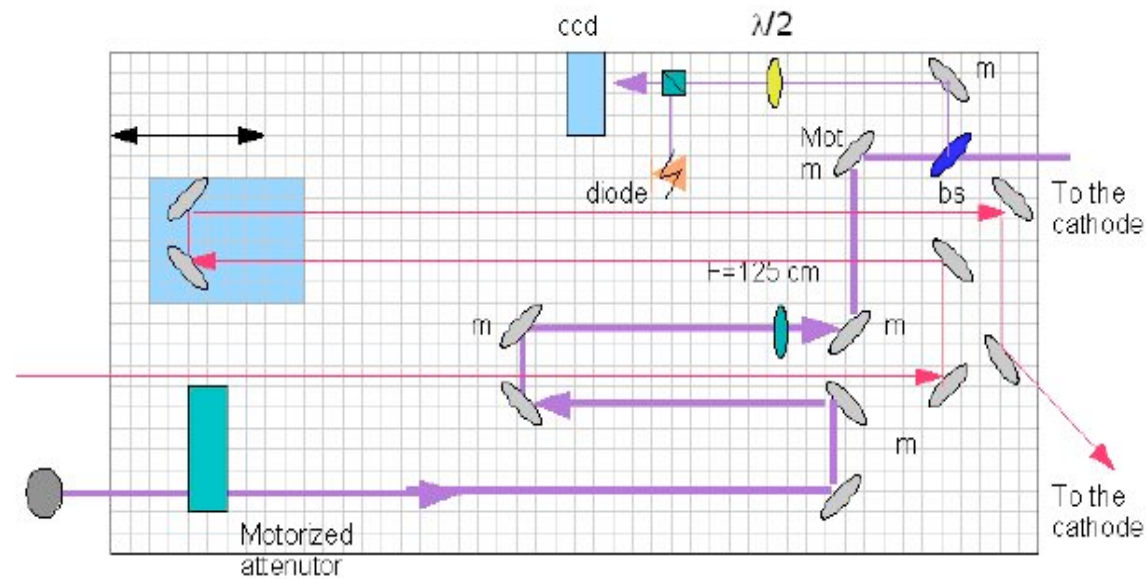
Changes every laser period

IR pulse as modulating E field

- The IR on the cathode synchronous with the UV pulse can be used to generate energy/charge modulation
- IR present characteristics:
 - Length < 1 ps
 - Energy > 10 mJ
 - Dimension diameter 10 – 0.1 mm
 - E field 2-200 MV/m

Gun table

IR optical transfer line



m = hr mirror 45 deg 266 nm

bs = thin beam splitter

Multiphoton Photoemission from a Copper Cathode Illuminated by Ultrashort Laser Pulses in an rf Photoinjector

P. Musumeci,¹ L. Cultrera,² M. Ferrario,² D. Filippetto,² G. Gatti,² M. S. Gutierrez,¹ J. T. Moody,¹ N. Moore,¹ J. B. Rosenzweig,¹ C. M. Scoby,¹ G. Travish,¹ and C. Vicario²

¹*Department of Physics and Astronomy, UCLA, Los Angeles, California 90095, USA*

²*Istituto Nazionale di Fisica Nucleare, Laboratori Nazionali Frascati, Via Enrico Fermi 40, 00044 Frascati, Italy*

(Received 24 November 2009; published 22 February 2010)

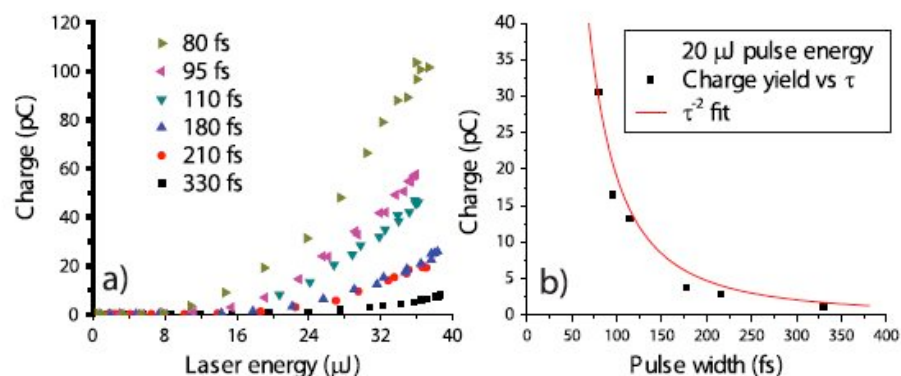


FIG. 3 (color online). (a) Yield vs different laser pulse length for 700 μm spot size at the cathode. (b) Charge as a function of pulse length for constant 20 μJ laser energy.

Accelerated @ SPARC

	IR e-beam	UV e-beam
Energy	158.9 MeV	158.8 MeV
Energy spread	7×10^{-4}	1×10^{-3}
Charge	150 pC	600 pC
Charge fluctuation	15% ptp	6% ptp
Bunch length	0.9 ps rms	1.85 ps rms

$$Q = J\tau A = CI^3\tau A = C \frac{E^3}{\tau^2 A^2}$$



Thank you